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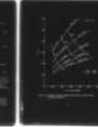
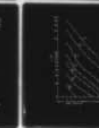
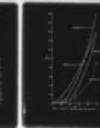
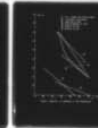
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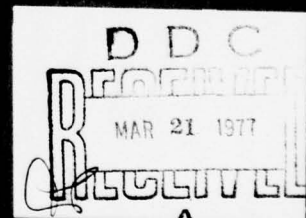
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THE COPLANAR ELECTRON TUBE

by

10
Mortimer H. Zinn

Advanced Concept and Techniques
Beam, Plasma and Display Technical Area

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December 1976

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ABSTRACT

Coplanar electron tubes consisting of emitting, controlling and collecting electrodes on a single heated plane have been proposed as a method of achieving high temperature and high radiation resistant devices. In order to design these devices, the scaling laws must be obtained. Using computer techniques it was determined that while the plate current of a device still followed a general three-halves power curve, the effect of electrode areas and electrode spacing are far less pronounced than in multiplanar tubes. A number of auxiliary problems were studied and data was obtained indicating that both alumina and beryllia would be suitable substrates for these devices. Single crystal alumina (sapphire) was found to be satisfactory, but polycrystalline alumina was not, indicating some reaction with active material from the cathode. Polycrystalline beryllia, on the other hand, was satisfactory. A trough strip line was developed for use in a distributed amplifier, power coplanar tetrode, but time did not permit, nor did results warrant, the construction of such a device.

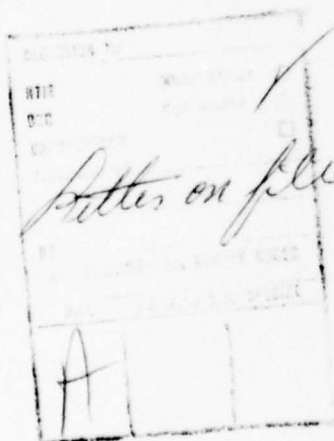


TABLE OF CONTENTS

	<u>Page No.</u>
INTRODUCTION	1
BACKGROUND	1
DISCUSSION	4
RESISTIVITY OF SUBSTRATES AS A FUNCTION OF TEMPERATURE	13
Limitations Due to Thermionic Emission Capabilities of the Photo-Lithographic Cathode	15
Limitations Due to Unwanted Thermionic Emission	16
Triode Design and Performance	16
The Trough Strip Line	20
Power Amplifier Tetrode Design	23
CONCLUSIONS AND RECOMMENDATIONS	33
ACKNOWLEDGMENTS	34
REFERENCES	35
APPENDIX A	36

FIGURES

1a. Coplanar Triode Showing Grid and Anode Sections Surrounding a Central Cathode.	4
1b. Coplanar Tetrode Showing Grid, "Screen" Grid, and Anode Sections Surrounding a Central Cathode.	4
2. The Coplanar Triode with a Second Cathode Stripe Surrounded by Grid and Anode.	5
3. Calculated Current as a Function of Matrix Points Above Plane.	6
4. Arbitrary Set of Matrix Points Used for Demonstration of Charge Flow Conditions.	7
5. Resistivity of Substrates at High Temperatures.	14
6. Triode Configuration.	17
7. Actual Vs Computed Triode Characteristics.	19

CONTENTS (Continued)

	<u>Page No.</u>
8a. Standard Trough Strip Line.	20
8b. Elevated Dielectric Trough Strip Line.	20
8c. Elevated Trough Strip Line.	20
9. Trough Strip Line Impedance For Configuration Shown in Figure 8a.	21
10. Trough Strip Line Impedance for Variation in Trough Sides as Shown in Figure 8b.	22
11. Trough Strip Line Tube Showing Two Tube Sections.	23
12. Multiple Line Input and Output ($n_o = n_i + 1$).	24
13. Unit Section Geometry. Each box is equal to 2.0×10^{-3} centimeters.	27
14a. Constant Thickness Variable Strip Width Impedance Tape.	29
14b. Constant Strip Width Variable Thickness Tape.	29
15. Required Cathode Length as a Function of Peak Current per Matrix Element.	32

TABLES

1. Variation Of Anode Current As A Function Of Cathode And Anode Size And Cathode To Anode Spacing	11
2. Triode Design Fabricated	18
3. Tetrode Design Objectives	25
4. Tetrode Design Computations	27

THE COPLANAR ELECTRON TUBE

INTRODUCTION

The coplanar electron tube was proposed as the active element in an integrated vacuum circuit (IVC) by Dore, Geppert, and Mueller while working at Stanford Research Institute. Information on the device was obtained primarily by private communications and finally by reports on the cathode phases of the program. The coplanar tube appeared to have two potential advantages. Small spacings between grid and cathode could be achieved and maintained using photo-lithographic techniques, since the two electrodes are located on the same substrate; and, since the entire device operates at cathode temperature (600 - 700°C), it should provide a device capable of operation at high temperatures, and at the same time have all of the capabilities of a vacuum device with respect to operation under high nuclear radiation exposures. These possible advantages together with the potential of constructing entire circuits on an insulating substrate, an IVC, indicated that the feasibility of the circuit and its potential use in Army equipment should be investigated. Problems to be evaluated were: theoretical performance capabilities of active coplanar devices; limitations due to substrate operation at high temperature; limitations due to thermionic emission capabilities of the photolithographic cathode; limitations due to unwanted thermionic emission from control and collector electrodes on the hot substrate; the performance of a simple triode; and the proper capabilities of devices which could be designed using basic coplanar principles. A program was initiated to investigate these various facets of the coplanar tube design.

BACKGROUND

The thermionic electron tube has evolved considerably since the first triode was constructed by introducing a coarse wire grid between the cathode and the anode of a vacuum diode. The grid was capable of controlling the flow of electron current by a relatively small change in voltage on the grid or control electrode. The current flowing to the anode of a three element tube obeys the Child-Langmuir space charge relationship originally derived by Child² for a vacuum diode:

$$I_b = G E_d^{3/2} \quad (1)$$

where I_b = the current to the anode

G = a constant designated perveance

E_d = equivalent diode voltage

-
1. B. Dore, D. Geppert, & R. Mueller, "Low Temperature Thermionic Emitter," NASA Contract No. NAS 12-607.
 2. C. D. Child, Phys Rev., 32, pp. 498, (1911).

The equivalent diode voltage is in its simplest approximation:

$$E_d = \mu E_g + E_b \quad (2)$$

where E_g = Voltage on the grid (negative for equation (1) to be accurate)

μ = Amplification constant

E_b = Voltage on the anode.

The amplification constant can be further defined by combining equations (1) and (2) and differentiating with respect to E_g , holding the plate current constant.

$$\begin{aligned} 0 &= \frac{\partial E_b}{\partial E_g} + \mu \\ \mu &= -\frac{\partial E_b}{\partial E_g} \end{aligned} \quad (3)$$

Another important tube characteristic can be defined as the transconductance, G_m , the change in plate current due to a change in grid voltages, with constant plate voltage or

$$\begin{aligned} G_m &= \frac{\partial I_b}{\partial E_g} = \frac{3}{2} \mu G (\mu E_g + E_b)^{1/2} \\ \text{but } (\mu E_g + E_b)^{1/2} &= \frac{I_b}{G}^{1/3} \\ \text{or } G_m &= \frac{3}{2} \mu G \left(\frac{I_b}{G} \right)^{1/3} = \frac{3}{2} \mu (G^2 I_b)^{1/3} \end{aligned} \quad (4)$$

The transconductance is thus a function of the perveance of the tube (which is dependent upon geometrical factors such as cathode and anode area and grid-to-cathode and grid-to-plate spacings) and the **current** level at which the tube is operating.

The transconductance and the μ of a triode are related to each other through the relationship:

$$\frac{\partial I_b}{\partial E_g} \cdot \frac{\partial E_b}{\partial I_b} = -\frac{\partial E_b}{\partial E_g} \quad (5)$$

$$\text{or } G_m \cdot r_p = \mu \quad (6)$$

where r_p = plate resistance

Equations (5) and (6) indicate that only two of the three triode characteristics are independent.

Of the three characteristics the transconductance is the most important one with respect to the bulk of applications of the triode as a power amplifier. It is used in a number of derived and "artificial" figures of merit, and such factors as gain and bandwidth (and therefore, gain-bandwidth product) are directly related to this factor. Since transconductance is proportional to the two-thirds power of the perveance constant G , which in turn is directly proportional to the area and inversely proportional to the interelectrode spacings, high transconductance can be achieved by increasing the area of the tube or decreasing the spacings. This cannot, however, be done without affecting the plate current drawn at a given diode voltage. Thus, attempts have been made to improve the transconductance to plate current ratio, which is one of the "artificial" figures of merit of a triode (or tetrode or pentode). The ratio, R , is

$$R = \frac{G_m}{I_b} = \frac{3}{2} \mu \left(\frac{G}{I_b} \right)^{2/3} \quad (7)$$

This ratio decreases with increasing current making it easier to obtain high values at currents approaching cut-off as is acceptable for small signal amplifiers, compared to high peak current levels, such as the peak of the RF, required for power amplifiers. As will be shown later, high levels of R are not an absolute necessity for power amplifiers. Indeed one must settle for a value of $R < R_{max}$ in order to maintain efficiency. The exact design value is a trade-off between tube size and efficiency. It is further limited by the peak current density capability of the cathode. These aspects of the problem have not been discussed in the previous literature.^{3,4}

The relationship shown in Equation (1) is based on a rigorous solution of Poisson's equation for a planar diode and similar results can be obtained for both the cylindrical and the spherical diode. There was no basis, however, for the belief that the equation could be applied directly to the coplanar diode. Since a simple conformal transformation could not be used to obtain a recognizable form of geometry for which a solution was available, it was decided to obtain a computer solution to the Poisson equation which could be used to obtain a relationship for scaling purposes. Two computer programs were written, one, by Capt. T. Freeman during his tour of duty at this Laboratory, which uses the conventional electron trajectory approach, and the second by the author using an approach which will be discussed below. Capt. Freeman's program seemed to give reasonable calculations for collected anode current of a coplanar triode. When trajectories were plotted, however, the program showed no electrons landing on the anode.

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3. J. R. Pierce, "Theoretical Limitation to Transconductance in Certain Types of Vacuum Tubes," Proc. IRE, 31, pp. 657 (Dec. 1943).
 4. G. R. Kilgore, "Beam-deflection Control for Amplifier Tubes," RCA Rev, 8, pp. 480-505 (Sep 1947).

Since debugging of the complex program by someone other than the author was difficult and extending it to a tetrode configuration would be even more difficult, all effort on this version of the program was dropped. A copy of the program is, however, maintained on file.

DISCUSSION

Theoretical Performance of a Coplanar Device

The coplanar triode, using a grid and anode on both sides of a cathode, is shown in Figure 1a. Figure 1b shows a tetrode design.

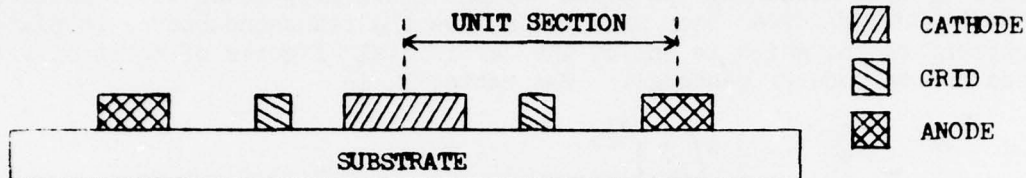


Figure 1a. Coplanar Triode Showing Grid and Anode Sections Surrounding a Central Cathode.

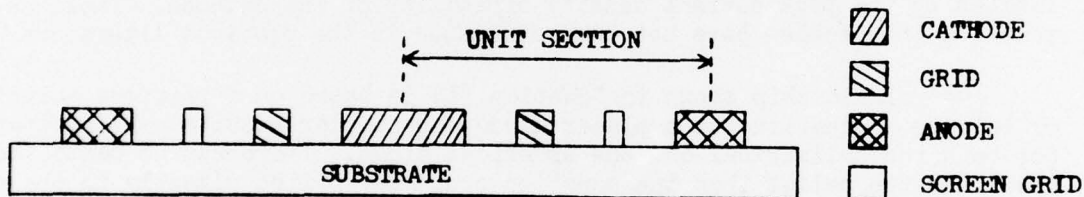


Figure 1b. Coplanar Tetrode Showing Grid, "Screen" Grid, and Anode Sections Surrounding a Central Cathode.

The dashed lines in each figure show the configuration of a unit section, which was used for computer calculation purposes. To obtain the current for any given length of the device shown, the calculated current per unit length would have to be multiplied by the actual length and by a factor of two since there are two equal sections of triode. Actually the number of sections can be iterated indefinitely with the section of anode outside of the dashed line serving as the anode for the next triode section as shown in Figure 2.

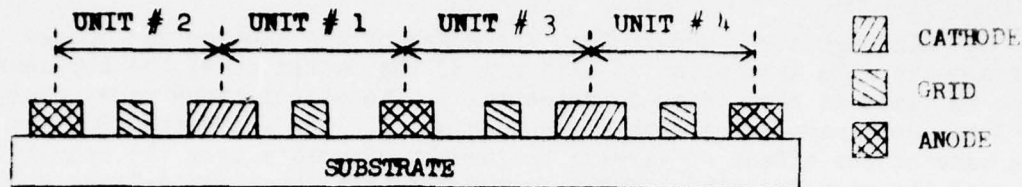


Figure 2. The Coplanar Triode with a Second Cathode Stripe Surrounded by Grid and Anode.

For the configuration shown in Figure 2 there are two additional triode sections or the total current, I_T ,

$$I_T = 2C_S L n$$

where C_S = Calculated section cathode current/unit length

L = Length

n = Number of cathode stripes

The computer program was, therefore, written based on the geometry shown with the assumption that the next set of points on the other side of the boundary line of the section would be a mirror image of the first set of points within the section. The program was written in a flexible manner so that the size of the electrodes and the spacing between them could be inputted. The program was originally written for a triode, but was later modified to cover the tetrode (in fact the program was general enough to cover a pentode form with a repeller beyond the anode in order to simulate devices constructed by Electron Emission Systems). The general approach to the solution will be discussed briefly. A copy of the final program (COPOLIP) Coplanar Poisson Solution Pentode, is included as Appendix A. The program is written in ALGOL and is designed to operate on a remote terminal of the Burroughs 5500 computer. Many of the results presented later, however, were obtained with the original triode program.

The program calculates the potential at all points in space as a function of the potential of the various electrodes on the plane. There are a number of artifices built into the program as a result of the way it has been written. They are as follows:

1. The thickness of the metal electrodes is automatically one matrix unit high, (the dimension of the matrix is an inputted variable) except for the raised grid design which will be discussed below.

2. The substrate in-between electrodes is assumed to be at cathode potential. This is not necessarily an accurate assumption, but greatly simplifies the calculation process. The program could be refined to take into

account the dielectric constant of the substrate and the actual potential of various parts of the surface.

3. Although the boundaries at the edges of the section can change continuously, the last point in each row of the matrix above the coplanar plane is fixed at zero (cathode potential). The calculations made, thus, are for a coplanar device with a grounded metal plane above it. Studies were made of the effect of varying the number of points from the operating plane to the grounded plane, and it was found that there was a large effect which did not tend to approach saturation until 21 points above the operating plane were included. At this point the program running time exceeded the time permitted for a single run (ten minutes at the time these tests were run). The computer was later constrained to 3 minutes on direct processing and ten minutes on "scheduled" processing. The **actual asymptotic value** was never found except by the extrapolation shown in Figure 3. The program was revised to permit the last point in each row to be adjusted to a value other than zero and while this gave higher values of current and lower values of u , the value which would be calculated if the last point was an infinite number of points away from the plane was not reached, i.e., the current still varied as a function of the number of points used in the row. It was, therefore, decided to let the last point remain at zero potential. This gave a result that was valid for a metallic plane above the active plane, which could be a valid configuration in a final package. For configurations without a metallic plane, a correction curve could be used based on the data collected and shown in Figure 3. Using this curve, a convenient number of points, but not less than 12, could be used for the actual computer computation, and the infinite number of points value could be obtained by multiplying the value obtained by the ratio of the infinite value (i.e., 15) to the value found on this curve for the number of row matrix points used.

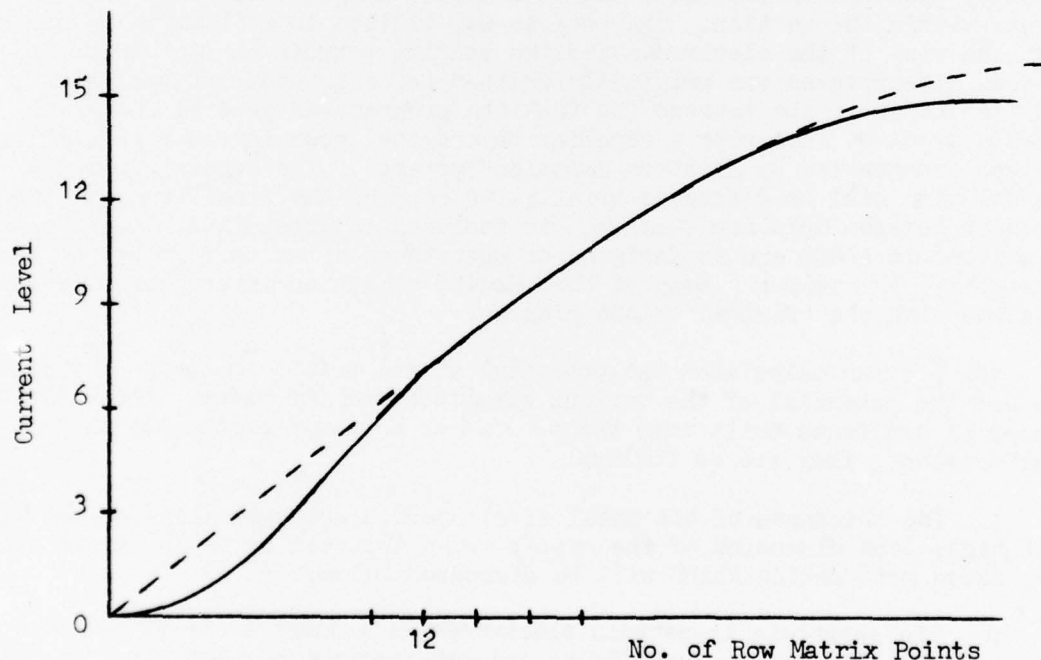


Figure 3. Calculated Current as a Function of Matrix Points Above Plane.

The first iteration of the program calculates the matrix point potential in the absence of space charge (the Laplace solution). A calculation is then made of the current drawn from the cathode based on the assumption that equation (1) is obeyed for the planar diode consisting of the cathode and the first set of matrix points immediately facing the cathode.

Instead of calculating exact electron trajectories from a reasonably large number of points at the cathode, the program then proceeds, by assuming that the charge at any given matrix point will flow to adjacent matrix points at a higher potential than the matrix point being checked, with the charge dividing in accordance with the ratio of the field between two points and the sum of the fields between the point from which current is flowing and all surrounding points. The points shown in Figure 4, are used to derive a typical charge flow expression.

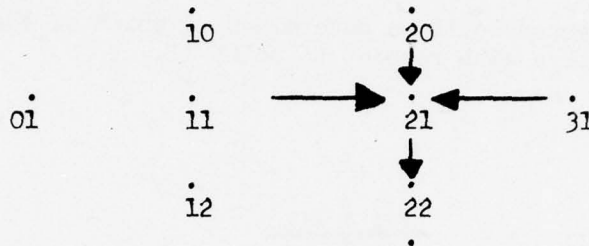


Figure 4. Arbitrary Set of Matrix Points Used for Demonstration of Charge Flow Conditions.

Assuming that the voltage at point 21 is greater than point 11 then

$$\begin{aligned}
 Q_{21(11)} &\propto Q_{11} \frac{E_{21-11}}{E_{21-11} + E_{12-11} + E_{10-11}} \\
 \text{or} \quad Q_{21(11)} &\propto Q_{11} \frac{E_{21-11}}{E_{21-11} + E_{12-11} + E_{01-11}} \\
 \text{or} \quad Q_{21(11)} &\propto Q_{11} \frac{E_{21-11}}{E_{21-11} + E_{10-11} + E_{01-11}} \\
 \text{or} \quad Q_{21(11)} &\propto Q_{11} \frac{E_{21-11}}{E_{21-11} + E_{12-11}} \\
 \text{or} \quad Q_{21(11)} &\propto Q_{11} \frac{E_{21-11}}{E_{21-11} + E_{10-11}} \\
 \text{or} \quad Q_{21(11)} &\propto Q_{11} \frac{E_{21-11}}{E_{21-11} + E_{01-11}}
 \end{aligned} \tag{8}$$

where $Q_{21(11)}$ = Amount of charge flowing to point 21 from point 11

E_{21-11} = Electric Field between points 21 and 11

E_{12-11} = Electric Field between points 12 and 11

E_{10-11} = Electric Field between points 10 and 11 etc.

The equation selected would be determined by which of the neighbor points were positive with respect to point 11.

$$\text{Since } E_{21-11} = \frac{V_{21} - V_{11}}{d}$$

where V_{21} = the potential at point 21

V_{11} = the potential at point 11

d = the matrix spacing (constant for all points)

The first relationship shown in Equation (8) would reduce to

$$Q_{21(11)} \propto Q_{11} \frac{(V_{21} - V_{11})}{(V_{21} - V_{11}) + (V_{12} - V_{11}) + (V_{10} - V_{11})}$$

$$\text{or } Q_{21(11)} \propto Q_{11} \frac{(V_{21} - V_{11})}{V_{21} + V_{12} + V_{10} - 3V_{11}}$$

To eliminate the proportional sign, we must take into account the current continuity equation, i. e., the current leaving point 11 must equal the current arriving at point 21 from 11, or, if the current from 11 were all going to 21 then,

$$I_{11 \rightarrow 21} = I_{21 \leftarrow 11}$$

$$P_{11} v_{11} = P_{21(11)} v_{21}$$

$$Q_{11} v_{11} = Q_{21(11)} v_{21}$$

$$Q_{21(11)} = Q_{11} \frac{v_{11}}{v_{21}} = Q_{11} \sqrt{\frac{v_{11}}{v_{21}}} \quad (9)$$

where $I_{11 \rightarrow 21}$ = Current flowing from 11 to 21

$J_{21 \leftarrow 11}$ = Current arriving at 21 from 11

v_{11} = Velocity of electrons at 11

v_{22} = Velocity of electrons at 21

This assumes that electrons left the cathode at zero velocity. For the case where the current divides between two or more points,

$$Q_{21(11)} = Q_{11} \sqrt{\frac{v_{11}}{v_{21}}} \left(\frac{(v_{21} - v_{11})}{v_{21} + v_{12} + v_{10} - 3v_{11}} \right) \quad (10)$$

and similarly for all the other possibilities of Equation (8).

Finally, the total charge at Q_{21} for the flow conditions shown by the arrows is calculated for Equation (11),

$$Q_{21} = Q_{21(11)} + Q_{21(20)} + Q_{21(31)} + Q_{21(22)} \quad (11)$$

After the total equilibrium charge flowing through each point is found, a second potential calculation iteration can be performed with the potential at each point being calculated based on the effects of nearest neighbor potentials and space charge reduction of potential, as has been derived by a number of authors.⁵

$$V_{21} = \frac{V_{11} + V_{20} + V_{31} + V_{22} + \frac{P_{21}h^2}{\epsilon}}{4}$$

$$V_{21} = \frac{V_{11} + V_{20} + V_{31} + V_{22} - \frac{Q_{21}}{Q_F}}{4} \quad (12)$$

where ϵ = Permittivity of vacuum

P_{21} = Charge density at 21

h = Distance increment between points

5. Ramo, Whinnery and Van Duzer, Fields and Waves in Communications Electronics, pp. 165, John Wiley & Sons, (1967).

Using Equation (12), corrected potentials are calculated for all of the matrix points. A record is also kept of the amount of change in potential so that the average change in potential can be calculated. The process of recalculating the potentials is continued until the average change is less than a level fixed in the program. In the process of these calculations, charges arriving at positive electrodes are automatically obtained and are translated into both current density and total current per matrix length per electrode. Printout of current density, electrode current and, if desired, potential and charge at each matrix point are obtained after the iteration process has been terminated.

Using the program, values of plate current vs. grid voltage could be calculated. By increasing the grid bias gradually, the cut-off of the device could be calculated by finding the value at which the plate current is reduced to zero, and since at $I = 0$ from Equation (1) and (2), we obtain

$$I_b = G E_d^{3/2} = G (u E_g + E_b)^{3/2} = 0$$

$$u E_g + E_b = 0 \quad (13)$$

$$u = - \frac{E_b}{E_g} = \left| \frac{E_b}{E_g} \right|$$

The transconductance was estimated by calculating the plate current change due to a small change in grid voltage at constant plate voltage.

$$G_m = \frac{I_{b2} - I_{b1}}{E_{g2} - E_{g1}} = \frac{\Delta I_b}{\Delta E_g} \approx \left(\frac{dI_b}{dE_g} \right) E_b \quad (14)$$

Examination of the program as written indicated that the relationship between current or current density and anode voltage obeys the three-halves power law. The currents therefore, are, calculated using a value of 1.0 volt for the anode voltage and zero volts for the cathode voltage. All other electrode potentials are scaled relative to 1.0 volt. The coplanar tube thus obeys the Child-Langmuir equation as described by Equation (1). To obtain the actual current at a specific voltage, we use

$$I_{act} = I_{calc} \left(\frac{V}{1 \text{ volt}} \right)^{3/2} \quad (15)$$

The only scaling law to be derived from the program, then, was the dependence of the permeance constant, G , on the geometry and spacing. Data was collected using the program written for the triode but with no grid present. The data is tabulated in Table 1. An examination of the data indicated that the current passed through a maximum value as the cathode size was increased at large anode to cathode spacings. The data for this condition is not included in the table and was not used in the curve fitting program described below since it would not meet the assumptions inherent in the equation for which a fit was sought (i.e., a linear log relationship). The conclusions drawn below from the derived equation apply only for relatively small cathode sizes.

TABLE 1. VARIATION OF ANODE CURRENT AS A FUNCTION OF CATHODE AND ANODE SIZE AND CATHODE TO ANODE SPACING

Cathode Size	4	4	4	4	4	3	2	1
Anode Size	8	7	6	5	4	4	4	4
Anode Current *d _{pk}	1x10 ⁹	1x10 ⁹	1x10 ⁹	1x10 ⁹	1x10 ⁹	1x10 ⁹	1x10 ⁹	1x10 ⁹
8	-	-	-	-	8.8	9.6	10.4	10.1
7	-	-	-	-	14.4	15.7	17.0	16.7
6	-	-	-	-	23.7	25.9	28.2	27.9
5	42.2	42.0	41.7	40.9	39.5	43.2	47.3	47.6
4	70.9	70.6	70.0	68.8	66.5	72.9	80.5	82.9
3	120.8	120.3	119.4	117.4	113.6	124.9	139.4	147.7
2	208.5	207.7	206.2	203.0	196.7	216.7	244.9	269.0
1	360.7	359.3	356.8	351.7	340.4	375.9	430.9	492.7

* d_{pk} = number of units spacing between plate and cathode.

Cathode and anode size are normalized.

The data was fitted to the following equation with anode voltage = 1 volt.

$$I = (k A_c^{b_1} A_p^{b_2} d_{pk}^{b_3}).$$

$$\text{or } \ln I = \ln k + b_1 \ln A_k + b_2 \ln A_p + b_3 \ln d_{pk}$$

where A_k = Cathode area in (matrix units)²

A_p = Anode area in (matrix units)²

k, b_1, b_2, b_3 = Coefficients to be determined by statistical analysis.

Using the techniques of method of moments⁶ for the analysis, the following results are obtained.

$$I = \frac{4.25 A_p^{.03} A_k^{.009}}{d_{pk}^{1.32}} \times 10^{-7} V^{3/2} \frac{\text{Amps}}{\text{matrix unit of length}} \quad (16)$$

This form of the equation is not of general use. The correlation was, therefore, repeated for an actual set of areas and spacings with the following results

$$I = \frac{4.89 A_p^{.002} A_k^{.0005}}{d_{pk}^{1.33}} \times 10^{-8} V^{3/2} \frac{\text{Amps}}{\text{Cm of length}} \quad (17)$$

where A_p and A_k are now expressed in cm² and d_{pk} in cm.

The perveance is, thus, not a very strong function of the electrode areas and varies inversely with the 4/3 power of the plate to cathode spacing instead of the strong dependence on cathode area and the inverse variation with the square of the spacing for a conventional bi-planar diode. Basically the cathode utilization is not uniform in the coplanar case, and the actual utilization varies with spacing and size to compensate somewhat for the difference in spacing. As a consequence of this non-uniform utilization, one must be sure that the maximum current density is not exceeded along the leading edge of the cathode.

Insufficient data was collected during the course of the program to permit a similar calculation of perveance of a triode to be made. One cannot automatically substitute an equivalent diode voltage for the triode case as

6. M. Ezekiel, Methods of Correlation Analysis, pp. 190-201, John Wiley & Sons, (1948).

is done in the multiplanar cathode. The general behavior, however, should be similar. The primary complicating factor will be that the size of the grid electrode will affect the plate to cathode spacing as well, which makes the relationship a more complicated one than in the conventional device.

While computer calculations of triode characteristics were being made, the undersigned conceived the idea that it would be possible to construct a "coplanar" device with the grid on the same substrate but extending to a higher level than either the cathode or the anode. The program was written to permit elevating the grid any number of matrix element spacings above the other electrodes. Computer runs (using the triode program) were performed for the case where the grid lies one matrix element higher than the cathode and anode. This results in higher values of amplification factor, μ , and transconductance to plate current ratio, R . This design was chosen for the power amplifier since it tended to minimize the length of electrodes required for a given power output, as will be shown later.

RESISTIVITY OF SUBSTRATES AS A FUNCTION OF TEMPERATURE

In order for the coplanar concept to be successful, it is necessary that the substrate used have a high resistivity at the operating temperature in order that bias potentials can be maintained on control electrodes. Kohl⁷ reviews the data originally published by Campbell,⁸ for a number of ceramics. Based on this data, only alumina and beryllia, of the ceramics conventionally used as electron tube envelopes, have a high enough resistivity at 700°C to be considered. The data shown for beryllia and magnesia is conflicting; the two sets of data differ by almost six orders of magnitude. Neither reference explains the differences, nor do they cite the original experiments so that the reader can determine the source of this difference.

Based on the data, however, it was decided to build the first coplanar devices using alumina substrates. In fact, to minimize the connection problem, a seven pin miniature ceramic stem was used with the pins cut-off flush with the normal inside surface. The metal electrodes of the coplanar triode were designed to use five of the seven pins as contacts and were deposited accordingly. The first devices processed were completed tubes. When processing was completed, the leakage between electrodes was far greater than would be predicted by the published high temperature ceramic data. An investigation was, therefore, made of the resistivity of the seven pin alumina miniature stem and other materials using only the grid-anode pattern of the triode. This would enable us to determine whether the resistivity difference was due to the ceramic itself being different from the sample covered in the literature, or whether the presence of active materials such as barium caused the low resistivity. Tests on the seven pin miniature stems (whose alumina purity could not be determined from our records), a number of alumina (99.5 percent purity) and of beryllia (99.5 percent purity), were performed. The results are shown in Figure 5. Tests performed on the alumina included a comparison of the use of chemical clearing of the substrates only prior to evaporation of the metal pattern, and the use of a 1000°C air firing after chemical

7. W. E. Kohl, Materials and Techniques for Electron Tubes, Reinhold, (1960).
8. I. E. Campbell, High Temperature Technology, John Wiley & Sons (1956).

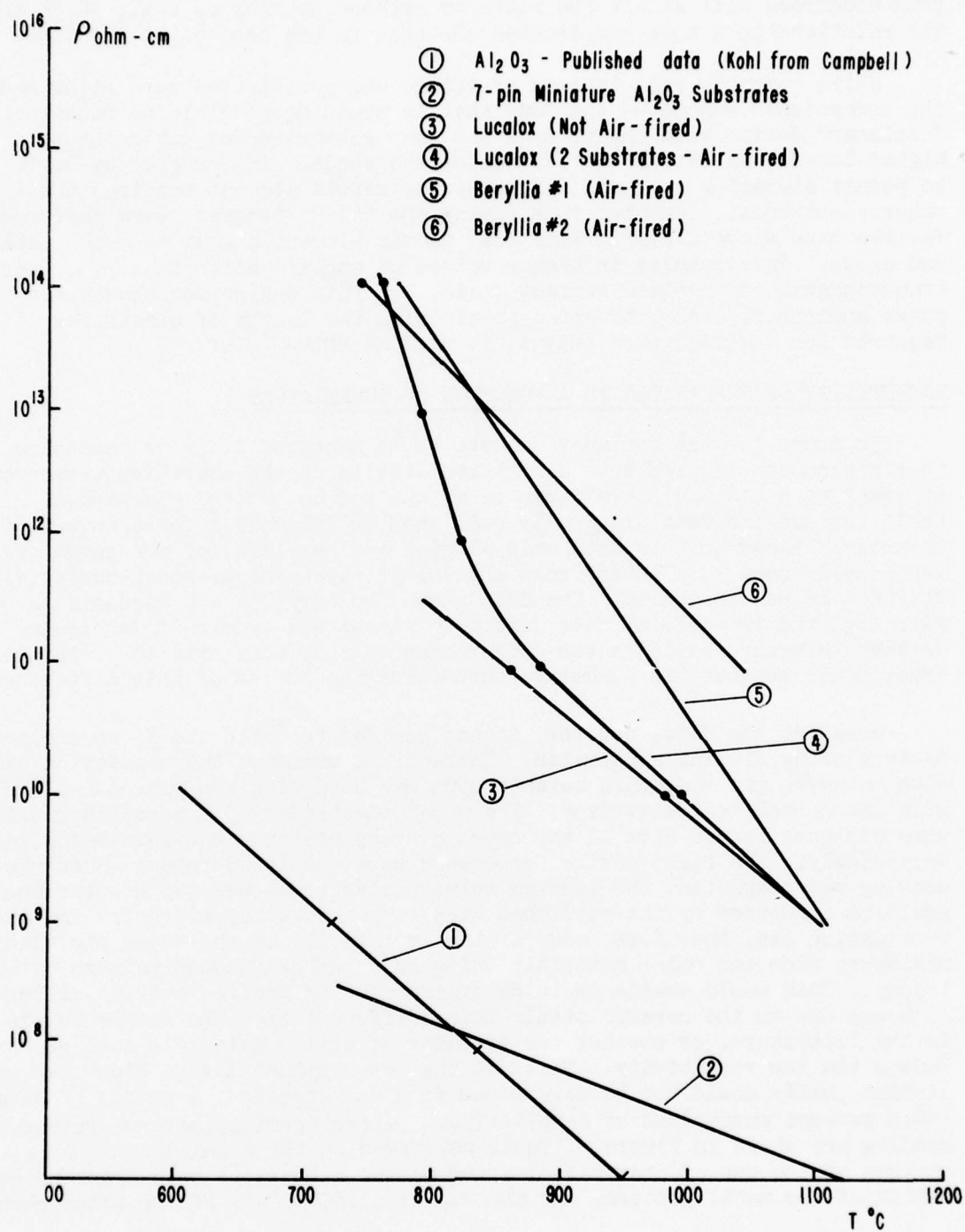


Figure 5. Resistivity of Substrates at High Temperatures

cleaning but before pattern evaporation. The following conclusions can be drawn from this series of experiments.

Limitations Due to Thermionic Emission Capabilities of the Photo-lithographic Cathode

1. The resistivity of the seven pin miniature stem at the temperature of interest was lower than the published values for alumina, but still high enough to have been useful, if other factors were not present.

2. The resistivity of high purity alumina is much higher than that shown in the literature and should be highly adequate for the coplanar substrate unless other factors, such as the presence of barium, come into play.

3. Air firing of the alumina results in a substantial improvement in resistivity particularly at lower temperature levels. The air firing cleaning step was adopted as a standard procedure on all substrates used thereafter.

4. The air-fired, high-purity beryllia data was within an order of magnitude of the higher level given by Campbell. The difference could be accounted for either by the approximation used to calculate resistivity for the highly non-standard configuration used for these measurements, or could represent sample variation (which was present in the samples tested). Unfortunately, time did not permit a comparison of non-air-fired material, which might have accounted for the wide range of data shown by Campbell. High purity beryllia, however, could serve as a useful substrate for coplanar devices barring interactions caused by the presence of active material.

The electron emitting material used in coplanar devices is one of the conventional mixes of triple (barium, strontium and calcium) carbonates used in thermionic devices. The primary difference is that in order to delineate the pattern of the cathode material, so that it is superimposed completely on a deposited metallic cathode substrate, the carbonates are placed in a binder of a photographically developable resist (KTFR) instead of the conventional amyl-acetate and nitro-cellulose binder usually used. In order to determine the effects of this binder and to verify the claims of low temperature emission capabilities,¹ a separate program was established to evaluate the cathode. The test program is covered in separate reports,^{9,10} and will only be briefly summarized here. The major results have been:

(a) Tests on conventional nickel sleeve cathodes have shown useful emission capabilities in the 650°C region. While this is not quite as low as the 600°C quoted by Dore, Geppert, etc.,¹ it still represents an improvement in low temperature operation over either standard oxide cathodes or the

1. B. Dore, D. Geppert, & R. Mueller, "Low Temperature Thermionic Emitter," NASA Contract No. NAS 12-607.

9. B. Smith, "Thermionic Emission from Oxide Coated Cathodes at Low Temperatures," USAECOM Technical Report, ECOM-3585, June 1972.

10. B. Smith, "Low Temperature Thermionic Cathode," Proc. IEEE-AGED Conf. on Electron Device Techniques, May 1973.

barium tungstate cathode. Life of over 5600 hours at a temperature of 650°C and an emission current density of 300 mA/cm² has been demonstrated.

(b) Delineated cathodes on coplanar substrates have been operated for over 5000 hours at a peak current density of 100 mA/cm². This operation has been obtained using a curve tracer as the operational test set. The substrate was fabricated by an outside source, but mounted and activated at this Laboratory. Substrates manufactured and activated by the existing source have been life tested under dc conditions at low current densities (tests were designed to detect charging effects in the substrate, which have not been observed) with no change in tube characteristics after 5000 hours of operation.

(c) Delineated cathodes fabricated at this laboratory have failed after operation up to 1000 hours. The cause of failure is not completely identified, but, in view of the other results obtained, it is believed to be due to poor adherence of the oxide cathode coating to the evaporated cathode electrode.

Limitations Due to Unwanted Thermionic Emission

Since all of the electrodes of a coplanar device are heated to the temperature on the substrate, a major question to be resolved is whether primary emission from control electrodes or from the anode will be experienced. To minimize this problem, we chose to use titanium as the electrode material for both the grid and the anode, while tungsten was used as the cathode material. Titanium has the property of reducing barium oxide that comes in contact with it, absorbing the oxygen, and releasing the barium which may then be deposited on a cooler structure. It should, therefore, be free from primary emission problems in the temperature range of the device. Although many problems with reverse grid current were encountered, these were all identified as leakage currents. No evidence of unwanted emission was noted. On the substrates and devices purchased for evaluation, which used a proprietary alloy for the control and collector electrodes, there also were no signs of unwanted emission. It is, therefore, considered highly feasible to fabricate coplanar devices and only obtain emission from the desired surfaces.

Triode Design and Performance

To verify the design of the coplanar triode, two types of tubes were planned. One was a simple triode whose basic purpose was to verify the computer calculations; the second was a power amplifier tetrode design to meet a specific objective. All of the substrate problems discussed above were noted with the triode design. These problems delayed the final stages of the program to the point that they were never executed. The tetrode design, however, did include one novel feature which may find application elsewhere, and for this reason, it will be discussed later.

The triode design chosen to check the computer program consisted of a device with four cathode stripes, a meanderline grid with eight full legs, and five anode stripes. The tube thus had eight of the unit sections shown in Figure 2. Although the original triodes were built with a diode-coupled input and a double diode (i.e., resistive) plate coupling, these features

were eliminated in later versions of the tube. The final tube was, therefore, of the type shown in Figure 6.

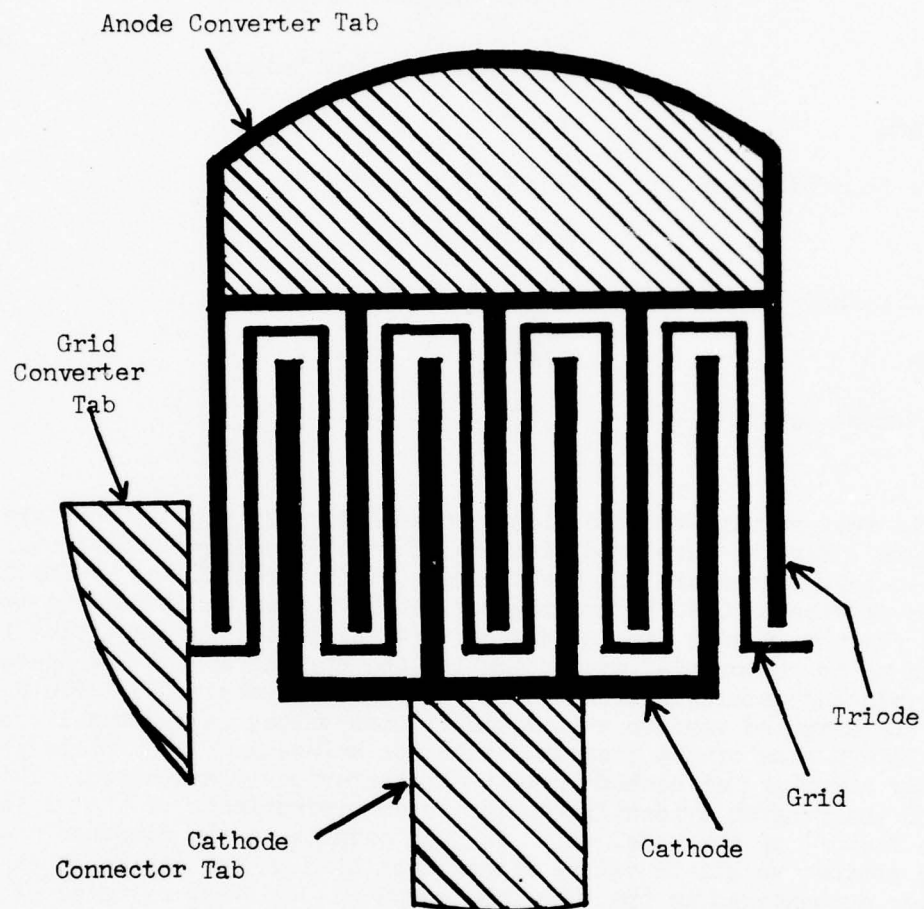


Figure 6. Triode Configuration

The dimensions of the various electrodes were designed to have the dimensions shown in Table 2. Also shown in the table are the number of matrix units corresponding to the dimensions for comparison with the computer calculations.

TABLE 2. TRIODE DESIGN FABRICATED

Element	Length (in.)	Matrix Units($\lambda = 6.35 \times 10^{-5} \text{m}$)
$\frac{1}{2}$ Cathode	0.005	2
Cathode to Grid Space	0.015	6
Grid	0.005	2
Grid to Cathode Space	0.010	4
$\frac{1}{2}$ Anode	0.005	2
Total Useful Length	1.875	-

The test results for the first successfully activated triode are shown in Figure 7 for the zero grid bias and -5 volt grid bias conditions. Also shown in this figure are the plate current values calculated by the COPOIT (triode version of COPOIP) program for the zero bias condition and two points for the -5 volt bias condition. The agreement for zero bias is considered to be reasonable, overestimating the current at the low plate voltage levels and underestimating it at the higher levels. The failure to check the computed results at the higher bias values is apparently due to the built-in bias of the program due to the maintenance of a plane above the coplanar structure at cathode potential as previously discussed. This artifact of the program evidently results in an overestimate of the μ (amplification factor) of the tube, which in turn results in the computer program giving greater weight to values of negative bias on the device than is actually encountered in the tube (the computed μ is approximately 5.8 for the geometry constructed, while the measured μ determined from cut-off data is approximately 2).

The tube for which data is presented was constructed on a sapphire substrate. No tubes were successfully constructed on the Lucalox (high purity alumina) substrates because of excessive leakage from grid to anode. It is, therefore, evident that some leakage mechanism is present in polycrystalline alumina (at least of the two types tested) that makes the material unsuitable for coplanar tube construction. Successful devices were constructed on polycrystalline beryllia so that the failures in alumina cannot be attributed to the polycrystallinity itself, but perhaps to the materials present at the grain boundaries in alumina compared to beryllia. The scope of the program did not permit further study of this problem.

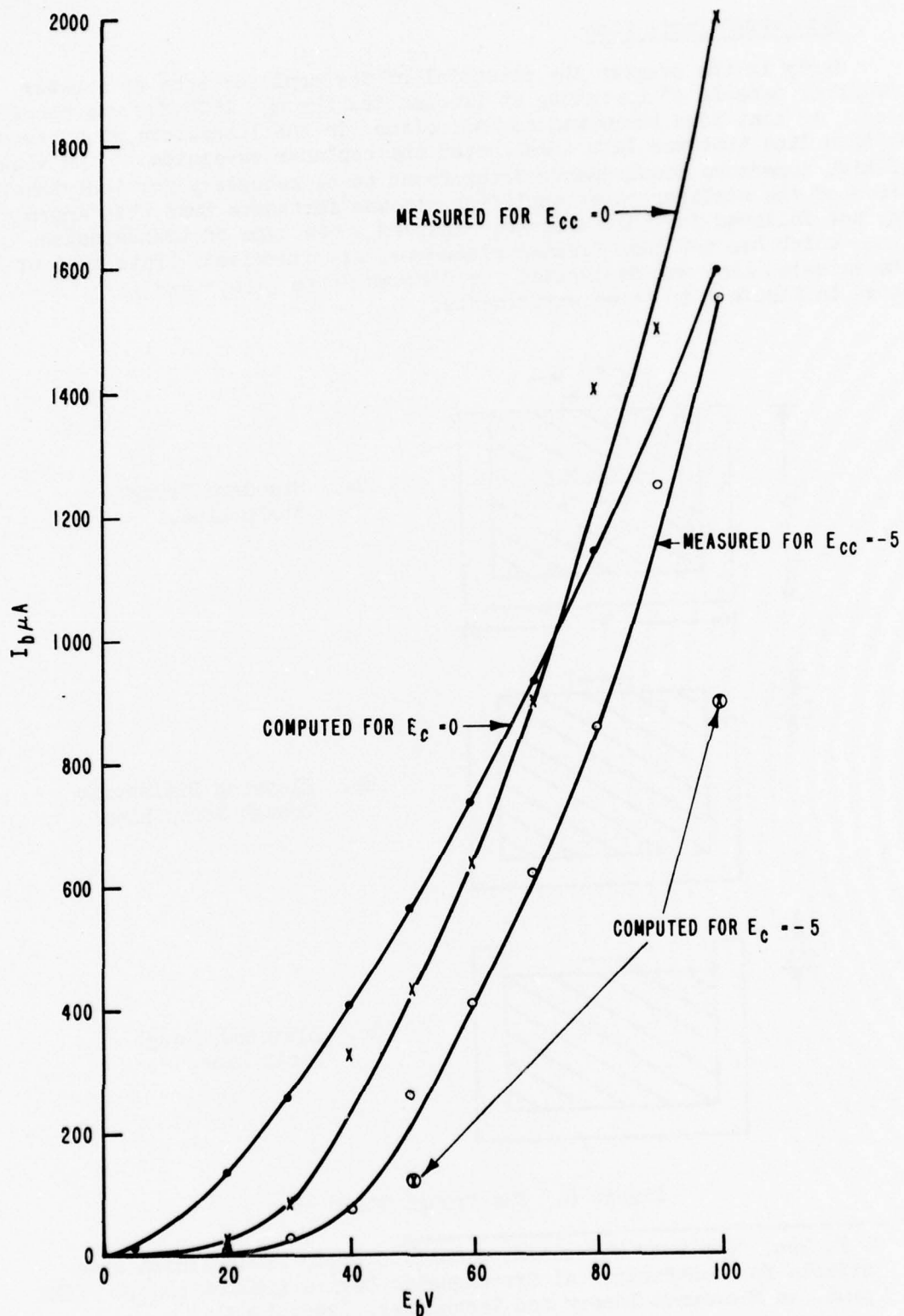
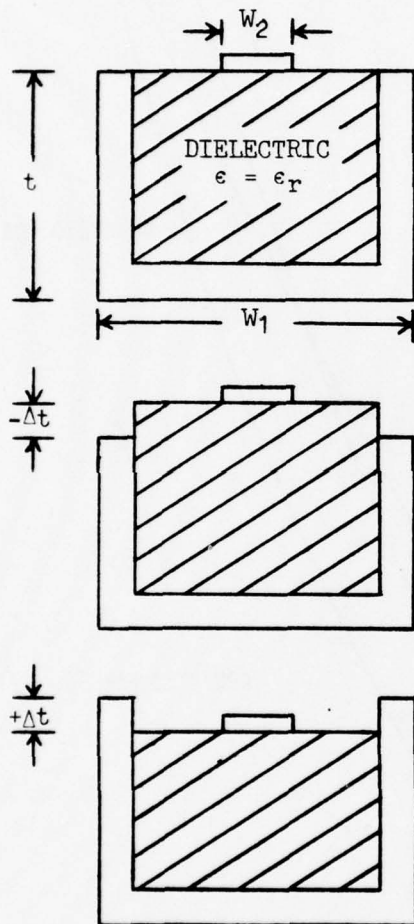


Figure 7. Actual Vs Computed Triode Characteristics

The Trough Strip Line

Early in the program the potential of the coplanar tube as a power amplifier capable of operating at frequencies through 1500 MHz was considered. At that time there was no indication in the literature of a transmission line that was later designated the coplanar waveguide.¹¹ In view of high impedance requirements later found to be necessary for individual lines of the coplanar power amplifier, it was fortunate that this approach was not followed for this program. Instead a new type of transmission line, which has not been treated elsewhere, was conceived. This type of transmission line was designated the "Trough Strip Line," and is shown in Figure 8 in three embodiments.



8a. Standard Trough Strip Line.

8b. Elevated Dielectric Trough Strip Line.

8c. Elevated Trough Strip Line.

Figure 8. The Trough Strip Line

11. C. P. Wen, "Coplanar Waveguide: A Surface Strip Transmission Line Suitable for Non-Reciprocal Gyromagnetic Device Applications," IEEE Trans. on Microwave Theory and Techniques, (Dec. 1969).

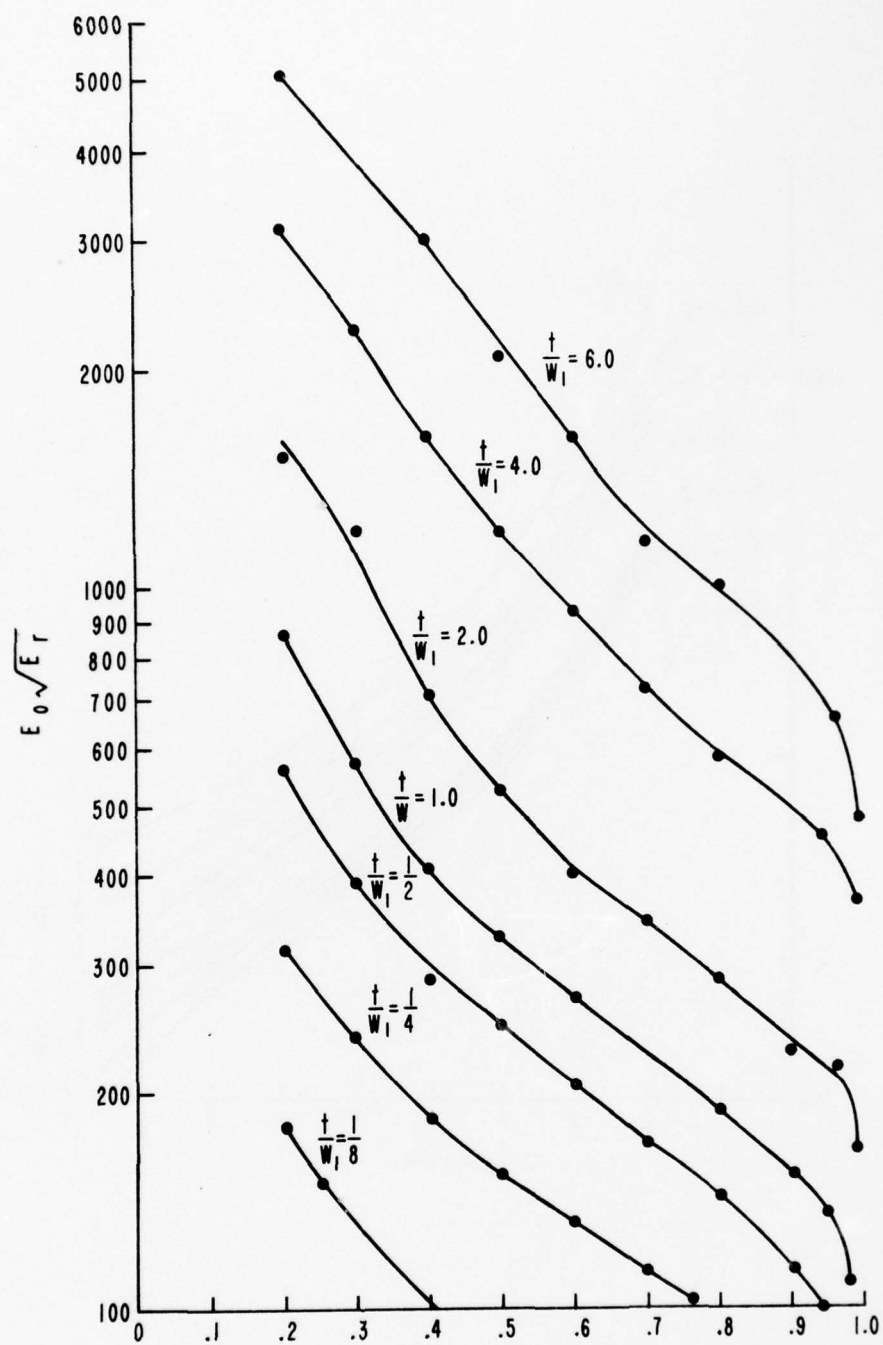


Figure 9. Trough Strip Line Impedance For Configuration Shown in Figure 8a.

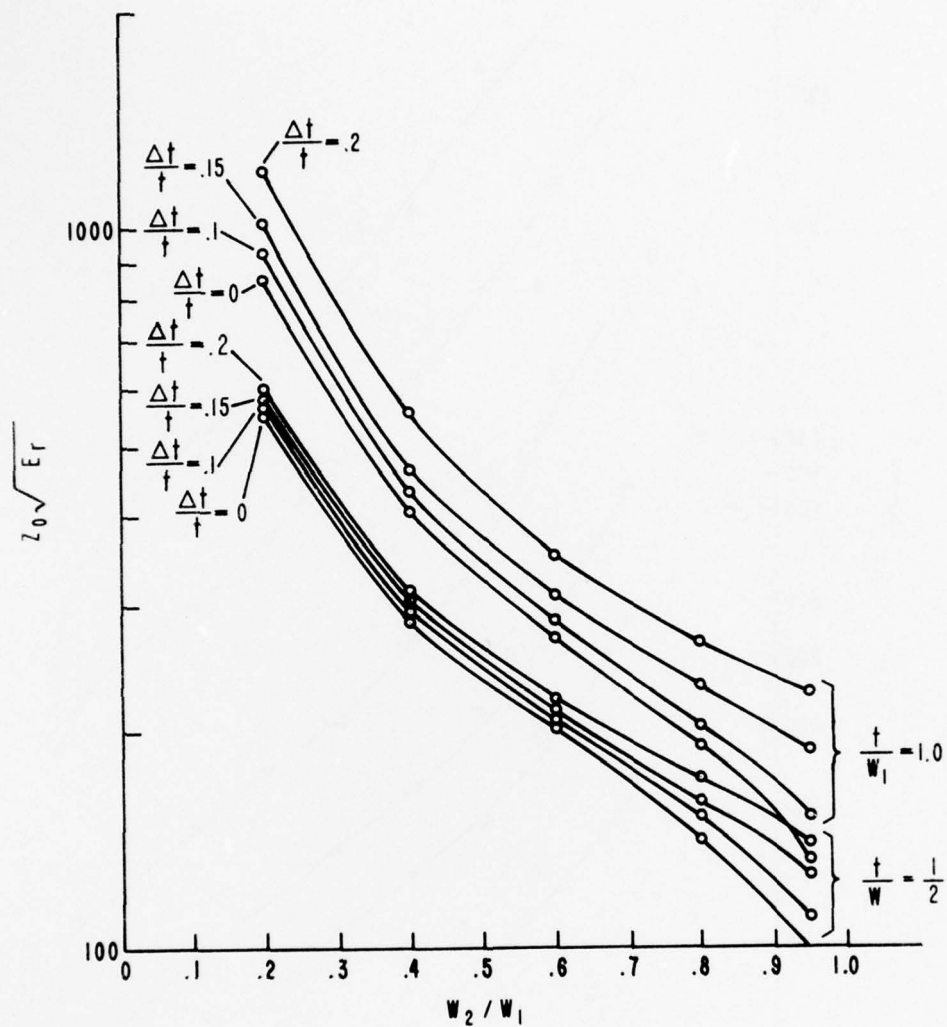


Figure 10. Trough Strip Line Impedance for Variation in Trough Sides as Shown in Figure 8b.

The case shown in Figure 8a was first checked using a model and gave sufficient promise to warrant analysis. The geometries of Figure 8a and 8b were analyzed by Capt. T. Freeman with the results shown in Figure 9 and Figure 10. The third case has not been analyzed as a transmission line, but, if the center conductor strip is considered to be a cathode and the two edges of the trough are the grids, the case can be recognized as that of a coplanar device with an elevated grid. The need for an elevated grid will be discussed below.

Power Amplifier Tetrode Design

To meet the power amplifier requirements, it was proposed to build a tube using the trough strip line by combining a number of such lines to form a pair of unit tube sections as shown in Figure 11.

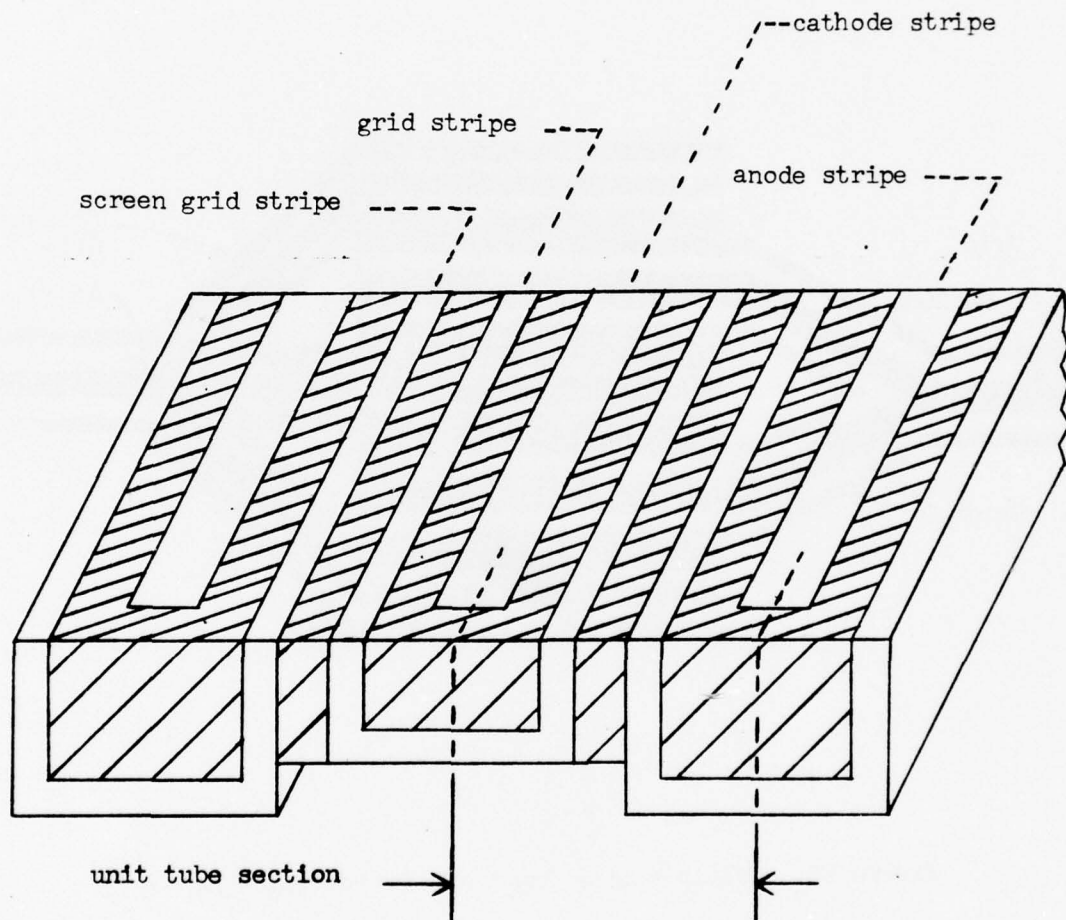


Figure 11. Trough Strip Line Tube Showing Two Tube Sections

If additional lines are needed in order to obtain the required device characteristics, they can be added by reiterating the unit tube section structure with the number of output lines always equal to one plus the number of input lines. When multiple lines are used, they would be diverged from the input and combined at the output, as shown in Figure 12, so that a single input and single output line could be used.

Figure 12 is illustrative in nature. If additional lines are required they could be achieved by combining groups of two inputs and three outputs or by other suitable combinations. It should be noted that the number of unit tube sections, where each unit section, as defined in Figure 1b, is equal to twice the number of input lines, i.e.

$$n_t = 2n_i. \quad (18)$$

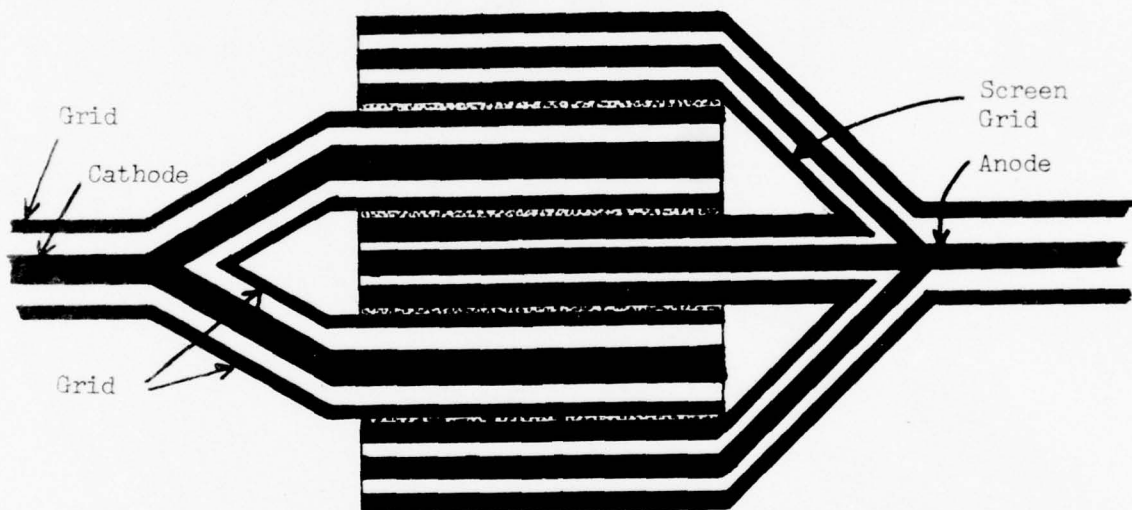


Figure 12. Multiple Line Input and Output ($n_o = n_i + 1$)

For the wide band trough strip line tube the following relationships apply

$$\text{Gain} = \frac{Z_o}{Z_i} \quad (19)$$

where Z_o = Output line impedance

Z_i = Input line impedance

$$\text{and } Z_i = \frac{1}{G_m} \quad (20)$$

where G_m = Transconductance

Equation (19) determines the input impedance required for a given output impedance (50 ohms is usually required) and a desired gain. Thus, for a gain of 25, an input impedance of 2 ohms would be required. For a gain of 20, the input impedance would be 2.5 ohms. The transconductance corresponding to the latter value of input impedance, based on Equation (20), is 400,000 μmhos .

A number of tube geometries were explored with the objective of meeting the required gain and transconductance, while minimizing a combination of active tube length and the number of unit sections. Calculations were made based on an objective of achieving 150 watts peak power at a duty of .06 with a gain of 20.

The design objectives and requirements for the tube are summarized in Table 3.

TABLE 3. TETRODE DESIGN OBJECTIVES

Factor	Symbol	Objective	Unit
Peak Power Output	P_o	150	w
Duty	D_u	0.06	
Output Impedance	Z_o	50	Ω
Gain	G	20	
Input Impedance	Z_i	2.5	Ω
Transconductance (1)	$G_m(1)$	400,000	μmhos
Transconductance (2)	$G_m(2)$	800,000	μmhos

In Table 3 the transconductance calculated from Equation (20) is listed as G_m (1). A value of twice this value must be achieved at the peak current level in order to meet the gain requirements at the fundamental frequency when operating as a single-ended Class B amplifier. This value is listed as G_m (2). The design computation and the equations used to make them are summarized in Table 4 for a tube operated as Class B amplifier.

All of the computations included in Table 4 are self-explanatory except for the calculation of minimum plate swing. This calculation uses the computer generated tube characteristics to determine the voltage at which the required peak current can be drawn under conditions which will result in the necessary transconductance. The equation is derived from the G_m to current ratio.

$$R = \frac{G_m}{i_{rf}} = \frac{G_m / \text{unit length}}{i} \quad (21)$$

where i = current for unit length

$$\text{but } \frac{G_m}{\text{unit length}} = \left(\frac{\partial i}{\partial e_c} \right)_{E_b} \approx \left(\frac{\Delta i}{\Delta e_c} \right)_{E_{min}} \quad (22)$$

Let $\Delta e_c = f E_{min}$ where f is a standard small fraction of the constant plate voltage, E_{min} .

Substituting (22) in (21) we have

$$R = \frac{\Delta i / (f E_{min})}{i} \quad (23)$$

Solving for E_{min}

$$E_{min} = \frac{\Delta i / i}{fR} \quad (24)$$

The $\Delta i / i$ values can be taken directly from computer tabulations which are made at an arbitrary voltage of 1.0 volt. The value of E_{min} tabulated is based on a unit geometry as shown in Figure 13.

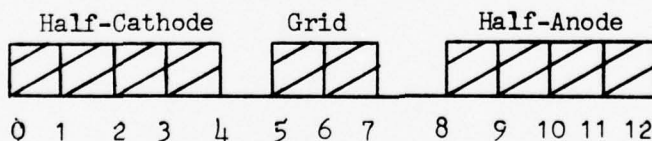


Figure 13. Unit Section Geometry. Each box is equal to 2.0×10^{-3} centimeters.

TABLE 4. TETRODE DESIGN COMPUTATIONS

Factor	Equation	Class B Amp.	Units
Peak Load Voltage	$e_L = (2P_o Z_o)^{1/2}$	122.5	v
Peak Load Current	$i_L = (2P_o / Z_o)^{1/2} = \frac{e_L}{Z_o}$	2.45	a
Peak Video Current	$i_b = i_L / 1.11$	2.21	a
Average Current	$I_b = i_b \cdot Du$	0.132	a
RMS Current	$i_p = i_b I_{b_b}$	0.541	a
Peak RF Current	$i_{rf} = \pi i_b$	6.93	a
Transconductance to Current Ratio	$R = C_m(2) / i_{rf}$	115.45	$\mu\text{mhos}/\mu\text{A}$
Min Plate Swing	$E_{\min} = (\Delta i / i) (1/P_o) \text{ (Note 1)}$	42.15	v
Plate Voltage	$E_{bb} = e_L + E_{\min}$	164.65	v
Power Input	$P_i = i_b E_{bb}$	363.9	w
Efficiency	$\eta = P_o / P_i$	41.2	%
Peak Current Density	$j_{rf}(\text{max}) \text{ (Note 2)}$	1.14	a/cm^2
RMS Current Density	$j_p(\text{max}) \text{ (Note 2)}$	0.089	a/cm^2

Note (1) - See Text for discussion and definitions of terms

Note (2) - Computed value for selected tube geometry

As can be seen, this is a triode geometry. At the time these computations were made, the computer program had not yet been modified to obtain tetrode calculations. Since the screen grid area used is small, it is assumed that most of the current will be collected at the anode. In the final design the screen-grid, insulator, and anode surface of the output trough transmission line will occupy the area of the triode anode.

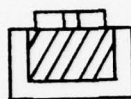
We must now resolve the question of how shall the required active length be obtained. We can select either a long device with a minimum number of input and output lines or a short device with a large number of lines. The long tube would provide a satisfactory solution at low frequencies only, however, where the wavelength is much greater than the required active length of tube. To achieve our objective of operation through 1500 MHz would require a length which is small compared to 20 cm., i.e., on the order of $\lambda/10$ or 2 cm. Using this length with the geometry calculated would result in approximately 660 tube units or 330 input lines. While this may not be any more difficult to construct, as far as fabrication is concerned, than a larger design with say 50 input lines, it leads to problems with the selection of transmission line impedance since an individual output line would require an impedance of $50 \times 330 = 165,000$ ohms in order to achieve the desired 50 ohms output impedance.

The proposed coplanar design, with its evaporated electrode fabrication technique, lends itself readily to an alternative approach, i.e., the tapered-line impedance, distributed amplifier originally proposed by General Electric to improve distributed amplifier efficiency. Normally, the output line of a distributed amplifier must be terminated with its characteristic impedance at the input end of the line. This results in the loss of half of the output power. With a tapered line design having a high impedance at the input and tapering to the required impedance at the output end, the efficiency of the distributed amplifier can be doubled.¹² With the higher efficiency feasible, a distributed amplifier whose length is not limited to a fraction of a wavelength can be used. The required impedance taper can be achieved in a trough strip line by one of two methods or a combination of the two. The two basic methods are illustrated in Figure 14. Using this approach, we can select a convenient number of input lines or a maximum length we do not wish to exceed from a fabrication standpoint.

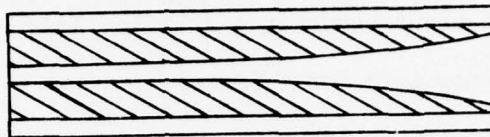
Before a final calculation is made, examination of the effect of elevating the grid will be made. To understand the effect, the contribution of the factor R, included in Table 4, must be determined.

12. Final Report, Contract DA 36-039-SC-90743, "Distributed Amplifier Tube," General Electric Company.

Front End View



Top View



Back End View

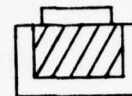
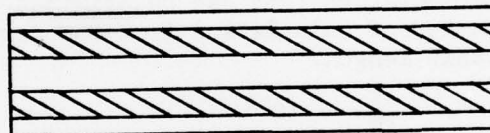


Figure 11a. Constant Thickness Variable Strip Width Impedance Tape.

Top View



Side View

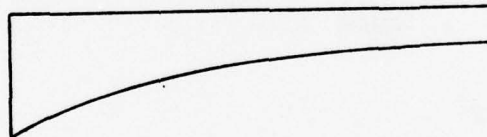


Figure 11b. Constant Strip Width Variable Thickness Tape.

To analyze this effect let

i = current per unit element at one volt in μA .

$I_{50} = (i/d) (50)^{3/2} \mu A/cm$ = current per cm at 50 volts

d = dimension of unit element

\hat{i} = required peak current in amps

G_m = required transconductance at \hat{i} in mhos

E_m = voltage required for \hat{i} (E_{min})

L = length of active area

$I_{em} = (i/d)(E_m)^{3/2} \frac{\mu A}{cm}$ = current per cm at E_{min}

From the total peak current required and the peak current achievable at E_{min} for each centimeter length (I_{em}), we can determine the total length of cathode required, i. e.,

$$L = \frac{\hat{i} \text{ amp}}{(I_{em}) \times 10^{-6} \text{ amp/cm}} = \frac{\hat{i}}{(i/d) (E_m)^{3/2} \times 10^{-6}} \text{ cm} \quad (25)$$

The value of E_m in Equation (25) can be eliminated by starting with the definition (and method of calculation from the computer data) of the transconductance per unit length.

$$\frac{G_m}{L} = \frac{\Delta I}{\Delta E} \times 10^{-6}$$

or

$$G_m = \frac{\Delta I(L)}{\Delta E} \times 10^{-6} \quad (26)$$

$$\text{but } \Delta I = (I_1 - I_2)$$

and $I_{em} \approx I_1$ when the change in E is small

$$\text{therefore } G_m = \frac{(I_1 - I_2)}{I_1} I_{em}(L) \times 10^{-6} \quad (27)$$

$$\frac{\Delta e}{E_m}$$

where Δe is the standard change in voltage used compared to 1.0 volt in the computer calculations, and $\Delta E = \Delta e E_m$.

$$\text{But } I_{em}(L) = \hat{i} \times 10^{-6}$$

$$\text{or } \hat{G}_m = \frac{\left(\frac{I_1 - I_2}{I_1} \right) \hat{i}}{\Delta e E_m}$$

solving for E_m and using the actual computer computations i_1, i_2 in the normalized current ratio

$$E_m = \frac{\left(\frac{i_1 - i_2}{i_1} \right) \hat{i}}{\hat{e} \hat{G}_m} \quad (28)$$

Substituting (28) in Equation (25) we have

$$L = \frac{\hat{i} \times 10^6 (\Delta e \hat{G}_m)^{3/2}}{\frac{i_1}{d} \left(\frac{i_1 - i_2}{i_1} \hat{i} \right)^{3/2}} \quad (29)$$

Using the values $\hat{i} = 6.93$ amperes
 $\hat{G}_m = 0.8$ mhos

obtained from the Tetrode Design Plan and $\hat{e} = .005$ used in the computer run-offs Equation (29) becomes

$$L = \frac{96.1 d (i_1)^{1/2}}{(i_1 - i_2)^{3/2}} \quad (30)$$

Equation (30) is plotted in Figure (15) for a unit spacing of 1.015×10^{-3} cm for a number of values of $\Delta i = i_1 - i_2$. These are equivalent to specific values of transconductance at the voltage of 50 volts and the current drawn at that voltage. The values of transconductance per centimeter of length are also shown on the figure. Also shown are lines of constant R , where R is a figure of merit arbitrarily taken at the 50 volt condition and equal to

$$R = \frac{G_m}{I} \frac{50}{50} \frac{\mu\text{mhos}}{\mu\text{A}}$$

One can see from the figure that geometries that lead to high values of R and high values of G_m per unit length result in smaller cathode areas to achieve a specific value of peak current and total transconductance at the peak current. The elevated grid coplanar tube gave just such a result.

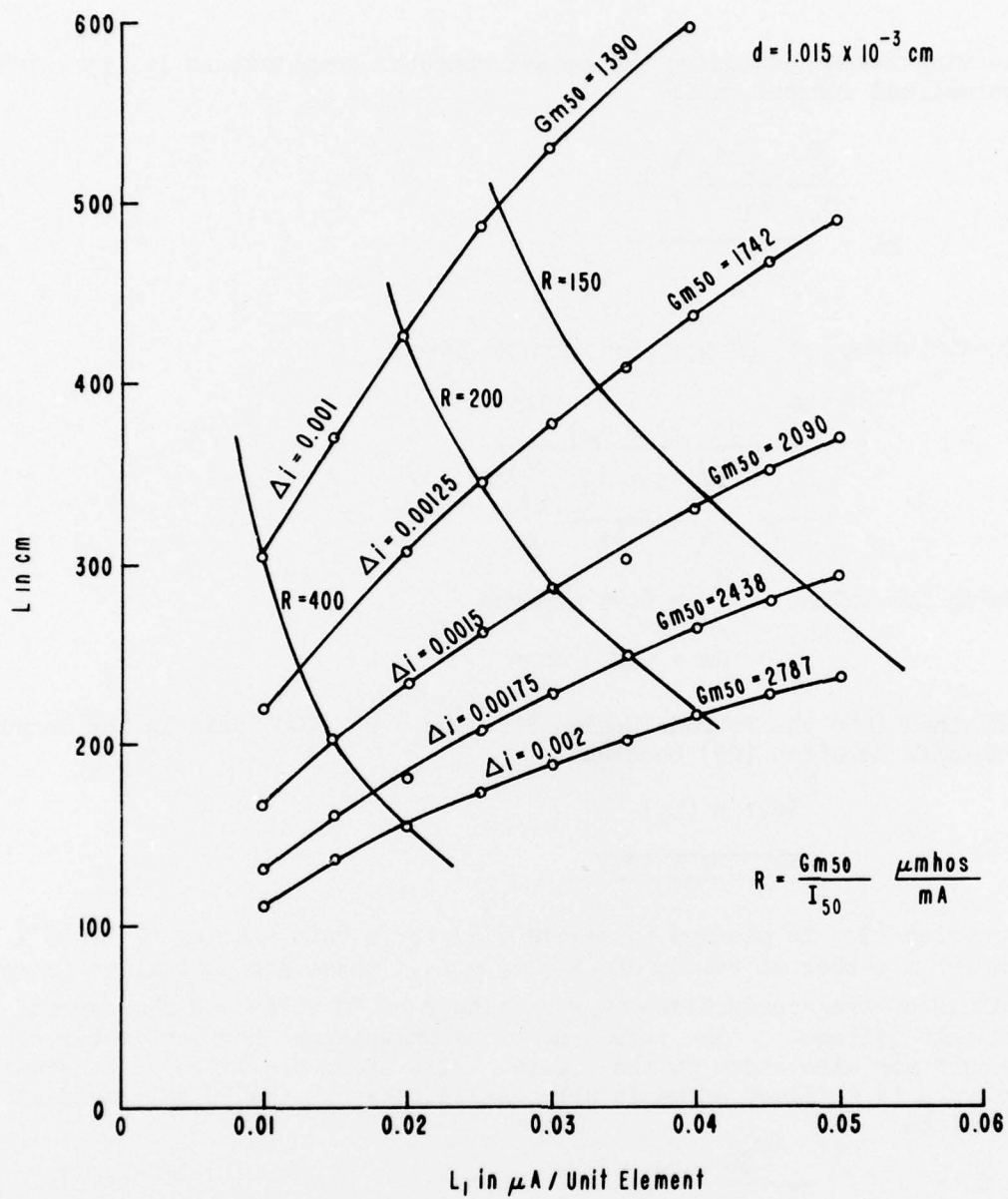


Figure 15. Required Cathode Length as a Function of Peak Current per Matrix Element.

For instance, at the unit element spacing used for Figure 15 using an unelevated grid with a Δi of .000125, a $Gm_{50} = 1742$ $\mu\text{mhos/cm}$ at an i_1 current of 7.1×10^{-8} amps per unit element was observed. The R value is far below the 150 $\mu\text{mhos/mA}$ level included in the figure. The required length of active device to achieve the peak current and Gm required was 571 centimeters. In contrast to this, the same geometry, except that the grid was elevated off of the plane by one matrix unit, gave a Δi of .000151, and a $Gm_{50} = 2090$ $\mu\text{mhos/cm}$ at an i_1 current of 3.16×10^{-8} amps per unit element. The R value is approximately 200, and only 283 centimeters of active tube would be required to achieve this condition. For a unit spacing of 2.0×10^{-3} cm, one could design an elevated grid, trough strip line tube that was 13.9 cm long using 40 tube units (20 output lines) for a total active tube length of 558 cms at a characteristic impedance of the strip line of 1000 ohms, compared to a non-elevated grid tube 14.5 cm long using 80 tube units (40 output lines) for a total active length of 1124 cms at a characteristic impedance of the strip line of 2000 ohms. Based on these results, it was concluded that an elevated grid structure was desired for the trough strip line tube.

It should be pointed out that one cannot simply design for the highest possible R value, such as that given by the use of the elevated grid and the closer spacing or by going to still higher elevated grids. Aside from the obvious fact that a limit would be reached determined by the peak current density capability of the tube, it can be shown that the higher R is the higher the value of E_{min} and, therefore, the lower the efficiency of the device. This is not obvious from Equation 24, which seems to indicate the opposite result. From Figure 15, however, we can see that as R increased $\Delta i/i$ also increases and actually increases more rapidly than R as the grid is elevated above the plane.

Tubes of the tetrode design calculated above were never constructed because of lack of time, and because the methodology proposed to achieve the multiple strip line construction involved the use of polycrystalline alumina using evaporation and etch techniques developed by Heynick and co-workers.¹³ Since the polycrystalline alumina failed to provide satisfactory triodes as discussed above, it was not considered worthwhile to attempt actual construction of the multiple element, trough strip line tetrode.

CONCLUSIONS AND RECOMMENDATIONS

The coplanar tube investigation was terminated based on the results described above for the following reasons: (1) While the reasons given for initiating the program, control of spacings and high temperature operation were verified, the tubes actually tested and the designs calculated from the computer programs did not show promise of exceedingly high performance devices. Indeed, the scaling law derived indicated that both tube element area and tube element spacing would play a lesser role than

13. Heynick and co-workers, Final Reports DA 28-043-AMC-01766, "Applied Research In Thin Film Field Emission Tubes," and DA 28-043-AMC-01261(E), "High Information Density Storage Surfaces," Stanford Research Institute.

that experienced in conventional tube design; (2) The wideband tetrode,¹⁴ for which the coplanar tube was being investigated as a driver tube, was found to be less practical than projected at the start of this program.

Although the program was terminated with the conclusion that coplanar tubes would not play a major role in Army electronics, a number of portions of the program have yielded significant results with respect to the general body of scientific knowledge.

a. The results on the high temperature resistivity of the insulators investigated supplement the available information and point out the need for explicit inclusion in the literature of the conditions used for treating the samples used for test purposes. The experiments performed here should be repeated with more standardized electrode configurations to provide greater confidence in the absolute number calculated for resistivity. The role of active materials on polycrystalline alumina surfaces in determining resistivity should also be determined.

b. The trough strip line developed for this program should have application in conventional transmission line applications. In addition, the tapered impedance concept advanced here could be applied to a multiplanar distributed amplifier tube which would be of much simpler construction than distributed amplifier tubes previously developed.

c. The computer programs developed for the purpose of this effort may be of use in future coplanar programs, which are initiated to take advantage of the radiation immunity characteristics of the device, which were not particularly pertinent to existing Army requirements.

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14. Final Report DAABC7-69-C-0439, "Triode Tetrode Amplifier Development," Bendix Corporation.

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APPENDIX A

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+COPOIP
1300 BEGIN
2000 $SA START1
3000 "POIP1"
4000 $SA START2
5000 INTEGER R,C,A,B,P,T,V,W,D,E,F,G,M,N,ITER,WR1,WR2,WR3,STI,DD,DE,WR0:
6000 REAL TH,S,H,DIF,JK,IS,IA,O1,O2,O3,O4,NUM,IG,DEN,AV,CT:
7000 REAL ARRAY U(C:50,-2:25),O(C:50,0:25),J(O:50):
8000 LABEL L1,L5,L6,L7,L8,L9,L47,L48,L49,L50,L51,L52,L53,L54,L55,L56,
9500 L57,L58,L59,L60,L61,L62,L63:
9800 FORMAT F1("TYPE M,N,A,BT,V,W,,<<<<]<<]<]=ZLVKR1,WR2,WR3,"):
10000 FORMAT F2(5F14.6,/):
11000 FORMAT F3(F14.6,/):
12000 FORMAT F4("IK IS"):
13000 FORMAT F5("IG IS"):
14000 FORMAT F6("IS IS "):
15000 FORMAT F7("IA IS"):
16000 FORMAT F8("JK IS"):
17000 FORMAT F9("JG IS"):
18000 FORMAT F10("JS IS"):
19000 FORMAT F11("JA IS"):
20000 FORMAT F12("ITERATIONS = ",I4,X5,"AVE. CHANGE=",F15.8):
21000 FORMAT F13(X20,"VOLTAGE MATRIX"):
22000 FORMAT F14(X20,"CHARGE MATRIX",/):
22500 FORMAT F15(X5,"EG1=",F4.2,"EG2=",F4.2,"ER=",F4.2):
23000 WRITE (TYPE,F1):
24000 READ (INPUT,M,N,A,B,P,T,V,W,D,DD,DE,E,F,G,H,WR0,WR1,WR2,WR3):
25000 READ (DATA,FOR R:=0 STEP 1 UNTIL M DO(FOR C:=0 STEP 1 UNTIL N
26000 DO (U(R,C))) :
27000 ITER:=0:
28000 L1:
29000 S:=0:
30000 ITER:=ITER+1:
32000 FOR R:=0 STEP 1 UNTIL M DO
33000 BEGIN
34000 LABEL LA1,LA2,LA3:
35000 IF R LEO A THEN GO TO LA1:
36000 IF R LEO B THEN GO TO LA2:
37000 IF R LEO P THEN GO TO LA1:
38000 IF R LEO T THEN GO TO LA2:
39000 IF R LEO V THEN GO TO LA1:
40000 IF R LEO W THEN GO TO LA2:
41000 IF R LEO D THEN GO TO LA1:
42000 IF R LEO DD THEN GO TO LA2:
43000 IF R LEO DE THEN GO TO LA1:
44000 IF R LEO E THEN GO TO LA2:
45000 IF R LEO M THEN GO TO LA1:
46000 LA1: FOR C:=0 STEP 1 UNTIL N-1 DO
47000 BEGIN
48000 TU:=(U(R-2*SIGN(R)+1,C)+U(R+2*SIGN(M-P)-1,C)+U(R,C-1)+U(R,C+1)
49000 -O(R,C)/(8.2460-12))/4:
50000 DIF:=ABS(TU-U(R,C)):
51000 S:=S+DIF:
52000 U(R,C):=TU:
53000 END:

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5400 GO TO LA3:
5500 LA2: FOR C:=1 STEP 1 UNTIL N-1 DO
5600 BEGIN
5700 TU:=(UIR-1,C1+UIR+1,C1+UIR,C-1)+UIR,C+1)-QIR,C1/(2.8460-12)
5800 )/4:
5900 DIF:=ABS(TU-UIR,C1):
6000 S:=S+DIF:
6100 UIR,C1:=TU:
6200 END:
6300 LA3: END:
6400 FOR R:=B+1 STEP 1 UNTIL P DO
6500 BEGIN
6600 GO TO IF UIR,2) GTR UIR,1) THEN L5 ELSE L6:
6700 L5: QIR,2):=(3.930-12)\(UIR,2)-UIR,1)\N:
6800 UIR):=QIR,2)\(5.9305)\NSORT(UIR,2)-UIR,1)/N*3:
6900 GO TO L7:
7000 L6: QIR,2):=0:
7100 L7: END:
7200 FOR R:=B+1 STEP 1 UNTIL P-1 DO
7300 BEGIN
7400 IF UIR+1,2) GTR UIR,2) THEN GO TO L55:
7410 IF UIR-1,2) GTR UIR,2) THEN GO TO L59:
7420 L55: IF UIR-1,2) GTR UIR,2) THEN GO TO L56:
7500 QIR+1,2):=QIR+1,2)+QIR,2)\(UIR+1,2)-UIR,2)/UIR+1,2)
7600 +UIR,3)-2\UIR,2)\NSORT(UIR,2)/UIR+1,2):
7610 GO TO L56:
7620 L59: QIR-1,2):=QIR-1,2)+(QIR,2)\(UIR-1,2)-UIR,2)/UIR-1,2)
7630 +UIR,3)-2\UIR,2)\NSORT(UIR,2)/UIR-1,2):
7640 GO TO L56:
7650 L56: QIR+1,2):=QIR+1,2)+(QIR,2)\(UIR+1,2)-UIR,2)/UIR+1,2)
7660 +UIR-1,2)+UIR,3)-3\UIR,2)\NSORT(UIR,2)/UIR+1,2):
7670 QIR-1,2):=QIR-1,2)+(QIR,2)\(UIR-1,2)-UIR,2)/UIR-1,2)+UIR
7680 -1,2)+UIR,3)-3\UIR,2)\NSORT(UIR,2)/UIR-1,2):
7700 L56: END:
7800 FOR R:=C STEP 1 UNTIL M DO
7900 BEGIN
8000 LABEL LB1, LB2, LB3, LB4, LB5, LB6, LB7, LB8, LB9, LB10, LB11, LB12, LB13, LB14, LB15, LB16, LB17,
8100 LB18, LB19, LB20, LB21, LB22, LB23, LB24, LB25, LB26, LB27, LB28, LB29,
8200 LB30, LB31, LB32, LB33, LB34, LB35, LB36, LB37, LB38, LB39, LB40, LB41,
8300 LB42, LB43, LB44, LB45, LB46:
8400 UIR,-2):=0:
8500 UIR,-1):=0:
8600 IF R LEQ A THEN GO TO LB1:
8700 IF R GTR B THEN GO TO LB3:
8800 LB2: STT:=1:
8900 GO TO LB4:
9000 LB3: IF R GTR P THEN GO TO LB5:
9100 STT:=3:
9200 GO TO LB4:
9300 LB5: IF R LEQ I THEN GO TO LB2:
9400 IF R LEQ V THEN GO TO LB1:
9500 IF R LEQ W THEN GO TO LB2:
9600 IF R LEQ D THEN GO TO LB1:
9620 IF R LEQ DD THEN GO TO LB2:
9640 IF R LEQ DE THEN GO TO LB1:
9700 IF R LEQ E THEN GO TO LB2:
9800 IF R LEQ F THEN GO TO LB1:
9900 IF R LEQ G THEN GO TO LB2:
10000 LB1: STT:=2:
10100 LB4: FOR C:=STT STEP 1 UNTIL N-1 DO

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10200 BEGIN
10300 IF U(R,C) LEQ 0 THEN GO TO L10:
10400 IF U(R,C-1) LEQ 0 THEN GO TO L11:
10500 IF U(R,C) LEQ U(R,C-1) THEN GO TO L11:
10600 NUM:=(U(R,C-1)X(U(R,C)-U(R,C-1))X(SQRT(U(R,C-1)/U(R,C))):
10700 IF U(R-2XSIGN(R)+1,C-1) LEQ U(R,C-1) THEN GO TO L12:
10800 IF U(R+2XSIGN(M-R)-1,C-1) LEQ U(R,C-1) THEN GO TO L13:
10900 IF U(R,C-2) LEQ U(R,C-1) THEN GO TO L14:
11000 DEN:=(U(R,C)+U(R-2XSIGN(R)+1,C-1)+U(R+2XSIGN(M-R)
11100 -1,C-1)+U(R,C-2)-4XU(R,C-1)):
11200 IF DEN EQL 0 THEN GO TO L11:
11300 Q1:= NUM/DEN:
11400 GO TO L15:
11500 L12: IF U(R+2XSIGN(M-R)-1,C-1) LEQ U(R,C-1) THEN GO TO L16
11600 IF U(R,C-2) LEQ U(R,C-1) THEN GO TO L17:
11700 DEN:=(U(R,C)+U(R-2XSIGN(M-R)-1,C-1)+U(R,C-2)
11800 -3XU(R,C-1)):
11900 IF DEN EQL 0 THEN GO TO L11:
12000 Q1:= NUM/DEN:
12100 GO TO L15:
12200 L13: IF U(R,C-2) LEQ U(R,C-1) THEN GO TO L18:
12300 DEN:=(U(R,C)+U(R-2XSIGN(R)+1,C-1)+U(R,C-2)
12400 -3XU(R,C-1)):
12500 IF DEN EQL 0 THEN GO TO L11:
12600 Q1:= NUM/DEN:
12700 GO TO L15:
12800 L14: DEN:=(U(R,C)+U(R-2XSIGN(R)+1,C-1)+U(R+2XSIGN
12900 (M-R)-1,C-1)-3XU(R,C-1)):
13000 IF DEN EQL 0 THEN GO TO L11:
13100 Q1:= NUM/DEN:
13200 GO TO L15:
13300 L16: IF U(R,C-2) LEQ U(R,C-1) THEN GO TO L19:
13400 DEN:=(U(R,C)+U(R,C-2)-2XU(R,C-1)):
13500 IF DEN EQL 0 THEN GO TO L11:
13600 Q1:= NUM/DEN:
13700 GO TO L15:
13800 L17: DEN:=(U(R,C)+U(R+2XSIGN(M-R)-1,C-1)-2XU(R,C-1)):
13900 IF DEN EQL 0 THEN GO TO L11:
14000 Q1:= NUM/DEN:
14100 GO TO L15:
14200 L18: DEN:=(U(R,C)+U(R-2XSIGN(R)+1,C-1)-2XU(R,C-1)):
14300 IF DEN EQL 0 THEN GO TO L11:
14400 Q1:= NUM/DEN:
14500 GO TO L15:
14600 L19: DEN:=(U(R,C)-U(R,C-1)):
14700 IF DEN EQL 0 THEN GO TO L11:
14800 Q1:= NUM/DEN:
14900 GO TO L15:
15000 L11: Q1:=0:

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15020 LI5:BEGIN
15040     REAL NUMER,DENOM;
15060     LABEL LD1,LD2,LD3,LD4,LD5,LD6,LD7,LD8;
15100     IF UIR-2\SIGN(R)+1,C1 LEQ 0 THEN GO TO LD1;
15200     IF UIR,C1 LEQ UIR-2\SIGN(R)+1,C1 THEN GO TO LD1;
15300     NUM:=(UIR-2\SIGN(R)+1,C1)\(UIR,C1-UIR-2\SIGN(R)+1,C1)\
15400     Sqrt(UIR-2\SIGN(R)+1,C1/UIR,C1);
15500     IF UIR-2\SIGN(R)+1,C-1 LEQ UIR-2\SIGN(R)+1,C1 THEN
15600         GO TO LD2;
15700     IF UIR-SIGN(R-1)+SIGN(1-R),C1 LEQ UIR-2\SIGN(R)+1,C1
15800         THEN GO TO LD3;
15900     IF UIR-2\SIGN(R)+1,C+1 LEQ UIR-2\SIGN(R)+1,C1 THEN
16000         GO TO LD4;
16100     DEN:=(UIR,C1+UIR-2\SIGN(R)+1,C-1)+UIR-SIGN(R-1)+
16200     SIGN(1-R),C1+UIR-2\SIGN(R),C+1)-4\UIR-2\SIGN
16300     (R)+1,C1);
16400     IF DEN EQL 0 THEN GO TO LD1;
16500     Q2:= NUM/DEN;
16600     GO TO L24;
16700     LD2:IF UIR-SIGN(R-1)+SIGN(1-R),C1 LEQ UIR-2\SIGN(R)+1,
16800         C1 THEN GO TO LD5;
16900     IF UIR-2\SIGN(R)+1,C+1 LEQ UIR-2\SIGN(R)+1,C1 THEN
17000         GO TO LD6;
17020     DEN:=(UIR,C1+UIR-SIGN(R-1)+SIGN(1-R),C1+UIR-2\
17040     SIGN(R)+1,C+1)-3\UIR-2\SIGN(R)+1,C1);
17060     IF DEN EQL 0 THEN GO TO LD1;
17080     Q2:= NUM/DEN;
17100     GO TO L24;
17200     LD3:IF UIR-2\SIGN(R)+1,C+1 LEQ UIR-2\SIGN(R)+1,C1
17300         THEN GO TO LD7;
17400     DEN:=(UIR,C1+UIR-2\SIGN(R)+1,C-1)+UIR-2\SIGN(R)+1,
17500     C+1)-3\UIR-2\SIGN(R)+1,C1);
17600     IF DEN EQL 0 THEN GO TO LD1;
17700     Q2:= NUM/DEN;
17800     GO TO L24;
17900     LD4: DEN:=(UIR,C1+UIR-2\SIGN(R)+1,C-1)+UIR-SIGN(R-1)
18000     +SIGN(1-R),C1-3\UIR-2\SIGN(R)+1,C1);
18100     IF DEN EQL 0 THEN GO TO LD1;
18200     Q2:= NUM/DEN;
18300     GO TO L24;
18400     LD5:IF UIR-2\SIGN(R)+1,C+1 LEQ UIR-2\SIGN(R)+1,C1
18500         THEN GO TO LD8;
18600     DEN:=(UIR,C1+UIR-2\SIGN(R)+1,C+1)-2\UIR-2\SIGN
18700     (R)+1,C1);
18800     IF DEN EQL 0 THEN GO TO LD1;
18900     Q2:= NUM/DEN;
19000     GO TO L24;
19100     LD6: DEN:=(UIR,C1+UIR-SIGN(R-1)+SIGN(1-R),C1-2\
19200     UIR-2\SIGN(R)+1,C1);
19300     IF DEN EQL 0 THEN GO TO LD1;
19400     Q2:= NUM/DEN;
19500     GO TO L24;
19600     LD7: DEN:=(UIR,C1+UIR-2\SIGN(R)+1,C-1)-2\UIR-2\
19700     SIGN(R)+1,C1);
19800     IF DEN EQL 0 THEN GO TO LD1;
19900     Q2:= NUM/DEN;
20000     GO TO L24;
20100     LD8: DEN:=(UIR,C1-UIR-2\SIGN(R)+1,C1);
20200     IF DEN EQL 0 THEN GO TO LD1;
20300     Q2:= NUM/DEN;
20400     GO TO L24;
20500     LD1: Q2:=0;
20520     END;

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20600 L24: IF U(R,C+1) LEQ 0 THEN GO TO L29;
20700 IF U(R,C) LEQ U(R,C+1) THEN GO TO L29;
20800 NUM:=0(R,C+1)\(U(R,C)-U(R,C+1))\SORT(U(R,C+1)/U(R,C));
20900 IF U(R-2\SIGN(R)+1,C+1) LEQ U(R,C+1) THEN GO TO L30;
21000 IF U(R+2\SIGN(M-R)-1,C+1) LEQ U(R,C+1) THEN GO TO L31;
21100 IF U(R,C+3\SIGN(N-1-C)-1) LEQ U(R,C+1) THEN GO TO L32;
21200 DEN:=(U(R,C)+U(R-2\SIGN(R)+1,C+1)+U(R+2\SIGN(M-R)-1,C+1)+U(R,C+3\SIGN(N-1-C)-1));
21300 IF DEN EQL 0 THEN GO TO L29;
21400 Q3:= NUM/DEN;
21500 GO TO L33;
21600 L30: IF U(R+2\SIGN(M-R)-1,C+1) LEQ U(R,C+1) THEN
21700 GO TO L34;
21800 IF U(R,C+3\SIGN(N-1-C)-1) LEQ U(R,C+1) THEN GO TO L35;
21900 DEN:=(U(R,C)+U(R+2\SIGN(M-R)-1,C+1)+U(R,C+3\SIGN(N-1-C)-1)-3\U(R,C+1));
22000 IF DEN EQL 0 THEN GO TO L29;
22100 Q3:= NUM/DEN;
22200 GO TO L33;
22300 L31: IF U(R,C+3\SIGN(N-1-C)-1) LEQ U(R,C+1) THEN GO
22400 TO L36;
22500 DEN:=(U(R,C)+U(R-2\SIGN(R)+1,C+1)+U(R,C+3\SIGN(N-1-C)-1)-3\U(R,C+1));
22600 IF DEN EQL 0 THEN GO TO L29;
22700 Q3:= NUM/DEN;
22800 GO TO L33;
22900 L32: DEN:=(U(R,C)+U(R-2\SIGN(R)+1,C+1)+U(R+2\SIGN(M-R)-1,C+1)-3\U(R,C+1));
23000 IF DEN EQL 0 THEN GO TO L29;
23100 Q3:= NUM/DEN;
23200 GO TO L33;
23300 L33: IF U(R,C+3\SIGN(N-1-C)-1) LEQ U(R,C+1) THEN
23400 GO TO L37;
23500 DEN:=(U(R,C)+U(R,C+3\SIGN(N-1-C)-1)-2\U(R,C+1));
23600 IF DEN EQL 0 THEN GO TO L29;
23700 Q3:= NUM/DEN;
23800 GO TO L33;
23900 L34: IF U(R,C+3\SIGN(N-1-C)-1) LEQ U(R,C+1) THEN
24000 GO TO L37;
24100 DEN:=(U(R,C)+U(R,C+3\SIGN(N-1-C)-1)-2\U(R,C+1));
24200 IF DEN EQL 0 THEN GO TO L29;
24300 Q3:= NUM/DEN;
24400 GO TO L33;
24500 L35: DEN:=(U(R,C)+U(R+2\SIGN(M-R)-1,C+1)-2\U(R,C+1));
24600 IF DEN EQL 0 THEN GO TO L29;
24700 Q3:= NUM/DEN;
24800 GO TO L33;
24900 L36: DEN:=(U(R,C)+U(R-2\SIGN(R)+1,C+1)-2\U(R,C+1));
25000 IF DEN EQL 0 THEN GO TO L29;
25100 Q3:= NUM/DEN;
25200 GO TO L33;
25300 L37: DEN:=(U(R,C)-U(R,C+1));
25400 IF DEN EQL 0 THEN GO TO L29;
25500 Q3:= NUM/DEN;
25600 GO TO L33;
25700 L29: Q3:=0;
25800 L33: IF U(R+2\SIGN(M-R)-1,C) LEQ 0 THEN GO TO L38;
25900 IF U(R,C) LEQ U(R+2\SIGN(M-R)-1,C) THEN GO TO L38;
26000 NUM:=0(R+2\SIGN(M-R)-1,C)\(U(R,C)-U(R+2\SIGN(M-R)-1,C))\SORT(U(R+2\SIGN(M-R)-1,C)/U(R,C));
26100 IF U(R+2\SIGN(M-R)-1,C+1) LEQ U(R+2\SIGN(M-R)-1,C) THEN GO TO L39;
26200 IF U(R+2\SIGN(M-R)-1,C-1) LEQ U(R+2\SIGN(M-R)-1,C) THEN GO TO L40;
26300 IF U(R+SIGN(M-1-R)-SIGN(R+1-M),C) LEQ U(R+2\SIGN(M-R)-1,C) THEN GO TO L41;
26400
26500

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26600 DEN:=(UIR,C1+UIR+2\SIGN(M-R),C+1+UIR+SIGN(M-1-R)
26700 -SIGN(R+1-M),C1-4\UIR+2\SIGN(M-P)-1,C1);
26800 IF DEN EQL 0 THEN GO TO L38;
26900 Q4:= NUM/DEN;
27000 GO TO L42;
27100 L39:IF UIR+2\SIGN(M-R)-1,C+1 LEQ UIR+2\SIGN(M-R)
27200 -1,C1 THEN GO TO L43;
27300 IF UIR+SIGN(M-1-P)-SIGN(R+1-M),C1 LEQ UIR+2\SIGN(M-R)
27400 -1,C1 THEN GO TO L44;
27500 DEN:=(UIR,C1+UIR+2\SIGN(M-R)-1,C-1+UIR+SIGN(M-1-R)
27600 -SIGN(R+1-M),C1-3\UIR+2\SIGN(M-R)-1,C1);
27700 IF DEN EQL 0 THEN GO TO L38;
27800 Q4:= NUM/DEN;
27900 GO TO L42;
28000 L40:IF UIR+SIGN(M-1-P)-SIGN(R+1-M),C1 LEQ UIR+2\SIGN
28100 (M-R)-1,C1 THEN GO TO L45;
28200 DEN:=(UIR,C1+UIR+2\SIGN(M-R)-1,C+1+UIR+SIGN(M-1-R)
28300 -SIGN(R+1-M),C1-3\UIR+2\SIGN(M-R)-1,C1);
28400 IF DEN EQL 0 THEN GO TO L38;
28500 Q4:= NUM/DEN;
28600 GO TO L42;
28700 L41:DEN:=(UIR,C1+UIR+2\SIGN(M-R)-1,C+1+UIR+2\
28800 SIGN(M-R)-1,C-11-3\UIR+2\SIGN(M-P)-1,C1);
28900 IF DEN EQL 0 THEN GO TO L38;
29000 Q4:= NUM/DEN;
29100 GO TO L42;
29200 L43:IF UIR+SIGN(M-1-P)-SIGN(R+1-M),C1 LEQ UIR+2\SIGN
29300 (M-R)-1,C1 THEN GO TO L46;
29400 DEN:=(UIR,C1+UIR+SIGN(M-1-P)-SIGN(R+1-M),C1-2\UI
29500 R+2\SIGN(M-P)-1,C1);
29600 IF DEN EQL 0 THEN GO TO L38;
29700 Q4:= NUM/DEN;
29800 GO TO L42;
29900 L44:DEN:=(UIR,C1+UIR+2\SIGN(M-R)-1,C-11-2\UIR+2\
30000 SIGN(M-R)-1,C1);
30100 IF DEN EQL 0 THEN GO TO L38;
30200 Q4:= NUM/DEN;
30300 GO TO L42;
30400 L45:DEN:=(UIR,C1+UIR+2\SIGN(M-R)-1,C+11-2\UIR+2\
30500 SIGN(M-R)-1,C1);
30600 IF DEN EQL 0 THEN GO TO L38;
30700 Q4:= NUM/DEN;
30800 GO TO L42;
30900 L46:DEN:=(UIR,C1-UIR+2\SIGN(M-R)-1,C1);
31000 IF DEN EQL 0 THEN GO TO L38;
31100 Q4:= NUM/DEN;
31200 GO TO L42;
31300 L38:Q4:=0;
31400 L42:Q(R,C1):=Q1+Q2+Q3+Q4;
31500 L10:END;
31600

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END;

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31700 FOR R:=0 STEP 1 UNTIL A,T+1 STEP T UNTIL M DO
31800 BEGIN
31900 IF U(R,2) LEQ 0 THEN GO TO L48;
32000 IF U(R,1) LEQ 0 THEN GO TO L48;
32100 GO TO IF U(R,1) GTR U(R,2) THEN L47 ELSE L47;
32110 L47: IF U(R+1,2) GTR U(R,2) THEN GO TO L61;
32120 IF U(R-2\SIGN(R)+1,2) GTR U(R,2) THEN GO TO L62;
32122 Q(R,1):=Q(R,2)\SQRT(U(R,2)/U(R,1));
32124 J(R):=Q(R,1)\5.9305\SQRT(U(R,1))/H*3;
32126 GO TO L52;
32130 L61: IF U(R-2\SIGN(R)+1,2) GTR U(R,2) THEN GO TO L63;
32200 Q(R,1):=Q(R,2)\(U(R,1)-U(R,2))/(U(R,1)+U(R+1,2)-2\U
32210 (R,2)\SQRT(U(R,2)/U(R,1));
32300 J(R):=Q(R,1)\(5.9305)\SQRT(U(R,1))/H*3;
32400 GO TO L52;
32410 L62: Q(R,1):=(Q(R,2)\(U(R,1)-U(R,2))/(U(R,1)+U(R-2\SIGN(R)+1,2)-8
32420 (U(R,2)\SQRT(U(R,2)/U(R,1));
32430 J(R):=Q(R,1)\5.9305\SQRT(U(R,1))/H*3;
32440 GO TO L52;
32450 L63: Q(R,1):=(Q(R,2)\(U(R,1)-U(R,2))/(U(R,1)+U(R+1,2)+U
32460 (R-2\SIGN(R)+1,2)-3\U(R,2)\SQRT(U(R,2)/U(R,1));
32470 J(R):=Q(R,1)\5.9305\SQRT(U(R,1))/H*3;
32480 GO TO L52;
32500 L48: Q(R,1):=0;
32600 J(R):=0;
32700 L52: END;
32710 FOR R:= A+1,V+1,D+1,F+1 DO
32720 BEGIN
32730 IF U(R,1) LEQ 0 THEN GO TO L57;
32740 IF U(R-1,1) LEQ 0 THEN GO TO L57;
32750 GO TO IF U(R-1,1) GTR U(R,1) THEN L58 ELSE L57;
32760 L58: QT:=Q(R,1)\SQRT(U(R,1)/U(R-1,1));
32770 Q(R-1,1):=Q(R-1,1)+QT;
32780 J(R-1):=Q(R-1,1)\5.9305\SQRT(U(R-1,1))/H*3;
32790 L57: END;
32800 FOR R:=T,W,E,G DO
32900 BEGIN
33000 IF U(R,1) LEQ 0 THEN GO TO L53;
33100 IF U(R+1,1) LEQ 0 THEN GO TO L53;
33200 GO TO IF U(R+1,1) GTR U(R,1) THEN L54 ELSE L53;
33300 L54: QT:=Q(R,1)\SQRT(U(R,1)/U(R+1,1));
33400 Q(R+1,1):=Q(R+1,1)+QT;
33500 J(R+1):=Q(R+1,1)\(5.9305)\SQRT(U(R+1,1))/H*3;
33600 L53: END;
33700 AV:=S/(M\N);
33800 GO TO IF AV LEQ 0.000005 THEN L49 ELSE L1;
33900 L49: IK:=IG:=IS:=IA:=0;
33950 WRITE (TYPE,F12,ITER,AV);
34000 WRITE(TYPE,F8);
34100 FOR R:=B+1 STEP 1 UNTIL P DO

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END PUNCH 10.5 SEC.

43

HISA-FM-93-77